

Nan-Scale Mechanical Measurements at Environmental Controls

16 June, 2023

Outlines:

Applications at High Temperature
Applications at Low Temperature
Applications at Humidity Levels

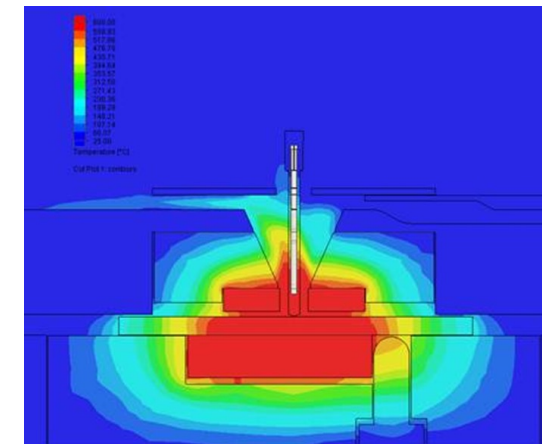
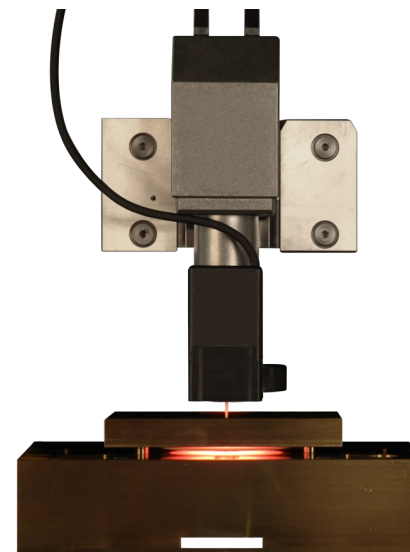
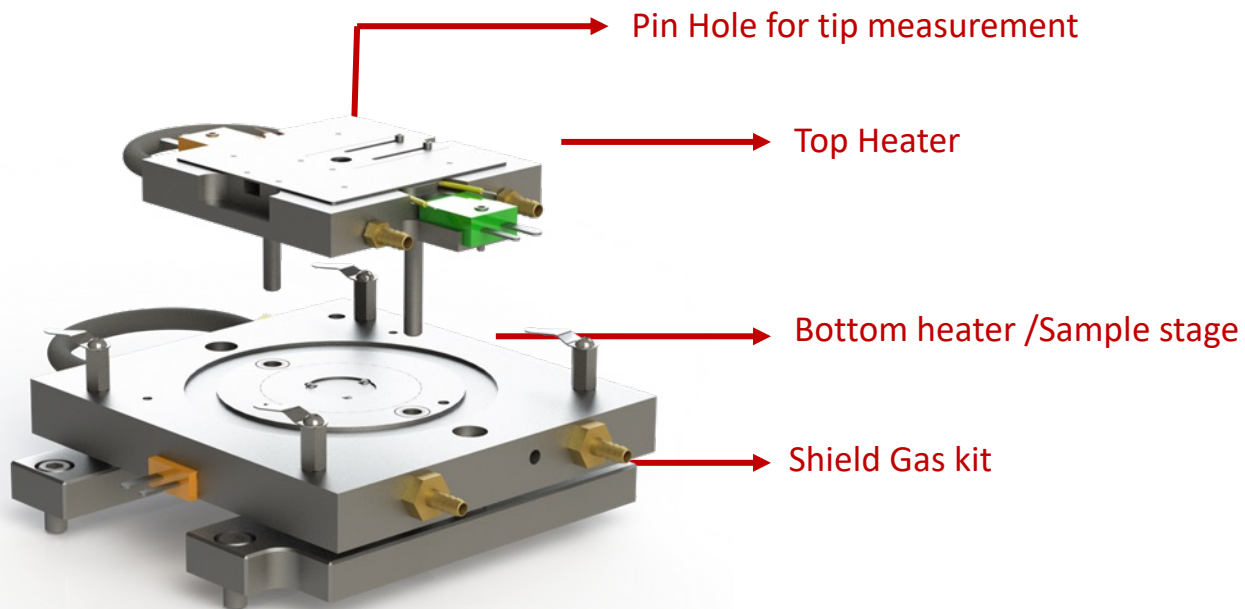
In-Operanto Environmental Chamber

xSol[®] - Heating, Cooling, Humidity
Heating: 800°C • Cooling: -120°C • Humidity: 10-75% RH



Applications at High Temperature

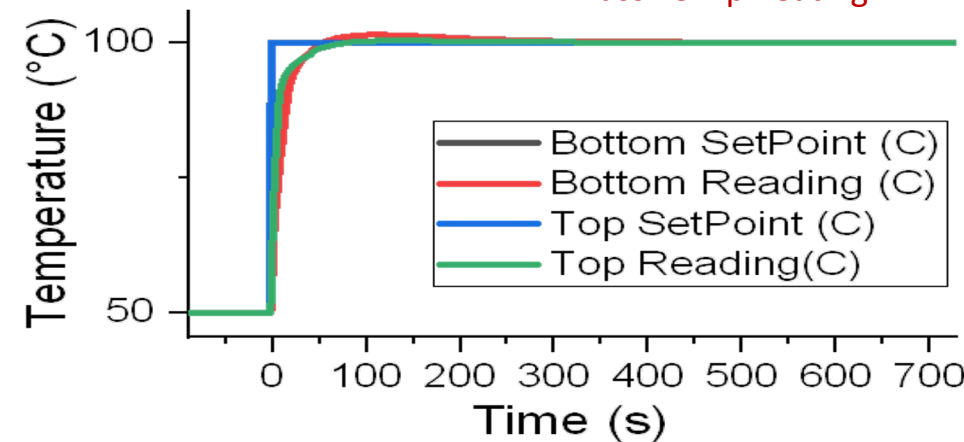
Controlled Atmosphere Systems



Heating Chamber

Passive Tip heating

xSol® - Heating, Cooling, Humidity
 Heating: 800°C • Cooling: -120°C • Humidity: 90% RH

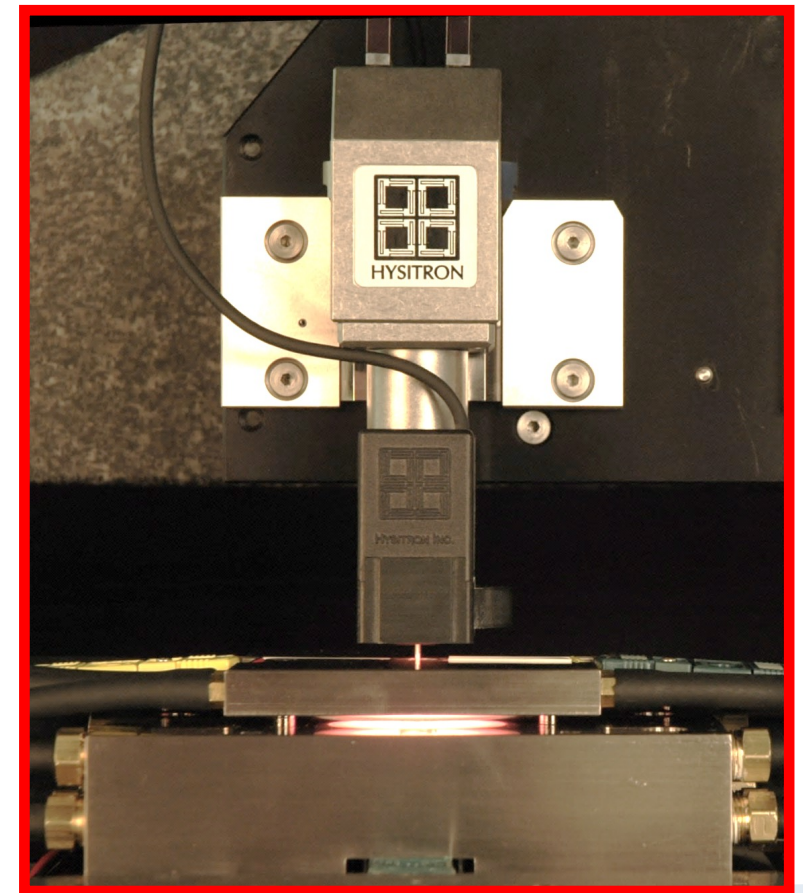
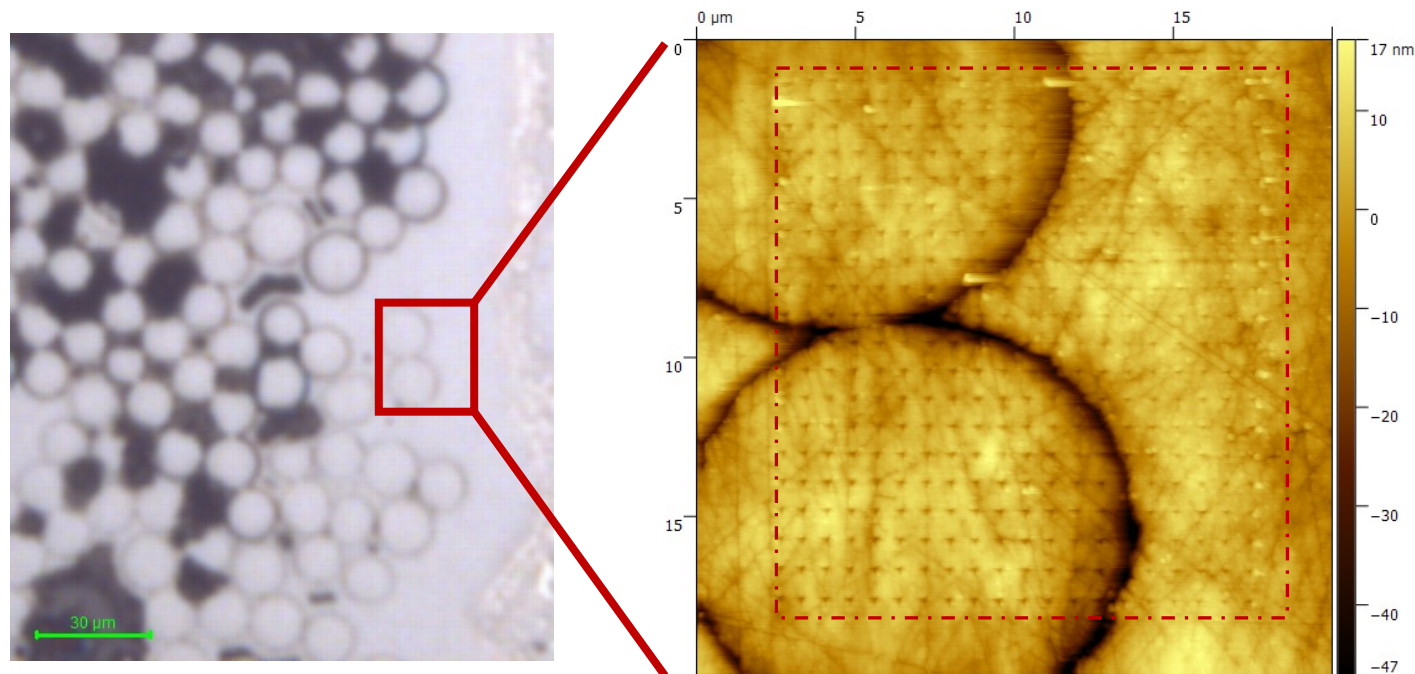


SILICON CARBIDE FIBER-MATRIX SAMPLE TESTED AT 400°C AND 800°C USING XPM HIGH THROUGHPUT INDENTATION

Application Case of XPM: Fiber-Matrix Composite

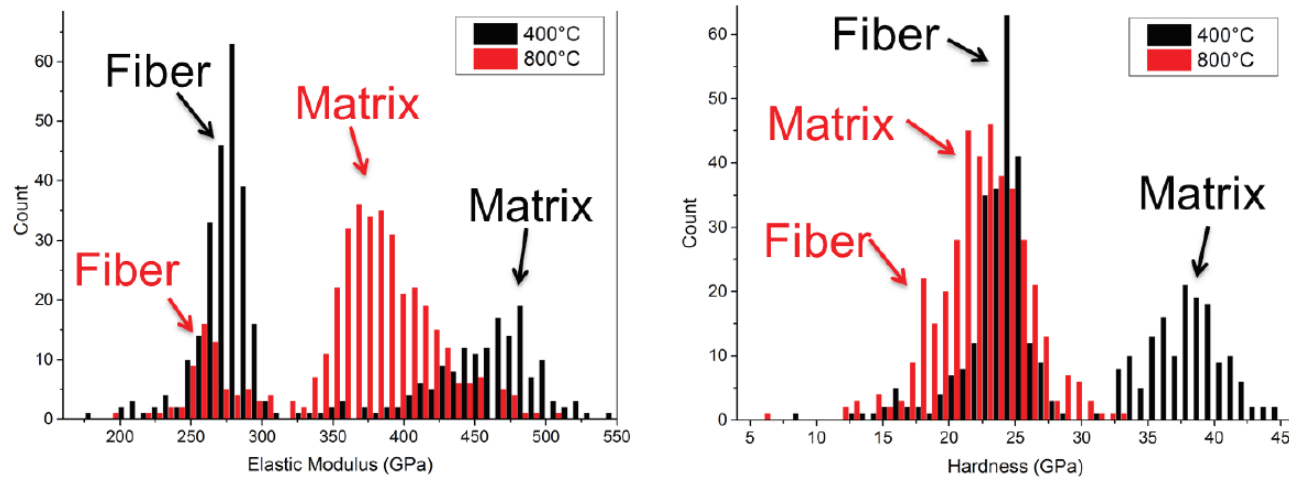
20X20 GRID PERFORMED IN 100 SECONDS

XPM for small size components at temperature levels

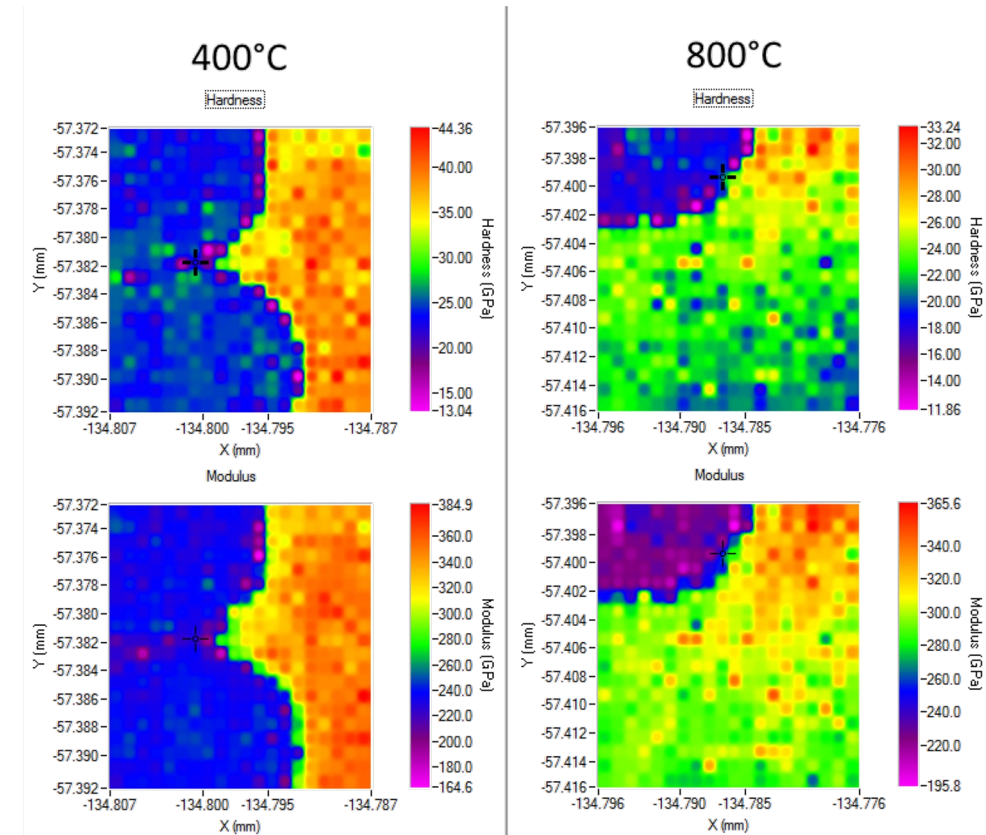


Application Case of XPM: Fiber-Matrix Composite

XPM for small size components at temperature levels



Histograms of silicon carbide fibre-matrix composite hardness and elastic modulus results obtained from XPM indentation testing at 400°C and 800°C

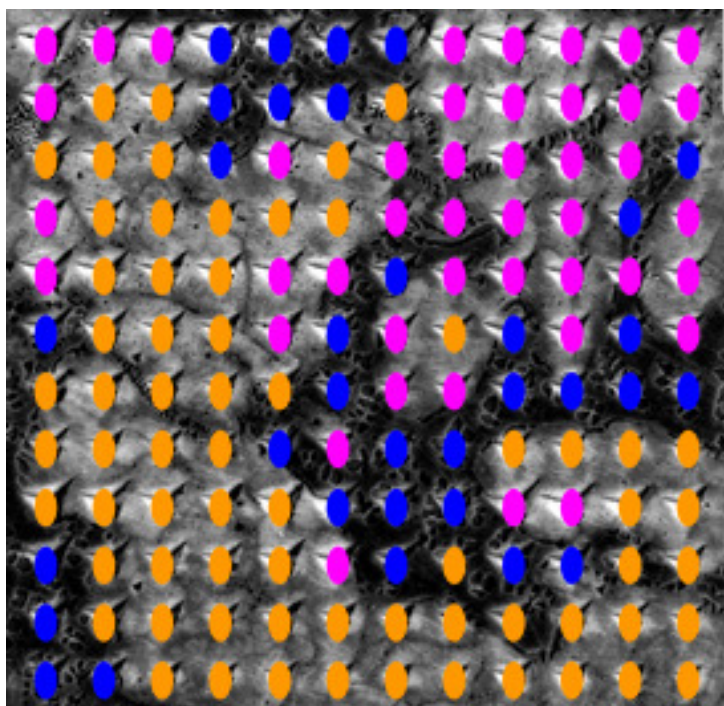


Fiber hardness and modulus, while lower, are also retained better at high temperature

Three Cluster Data at Temperature Levels

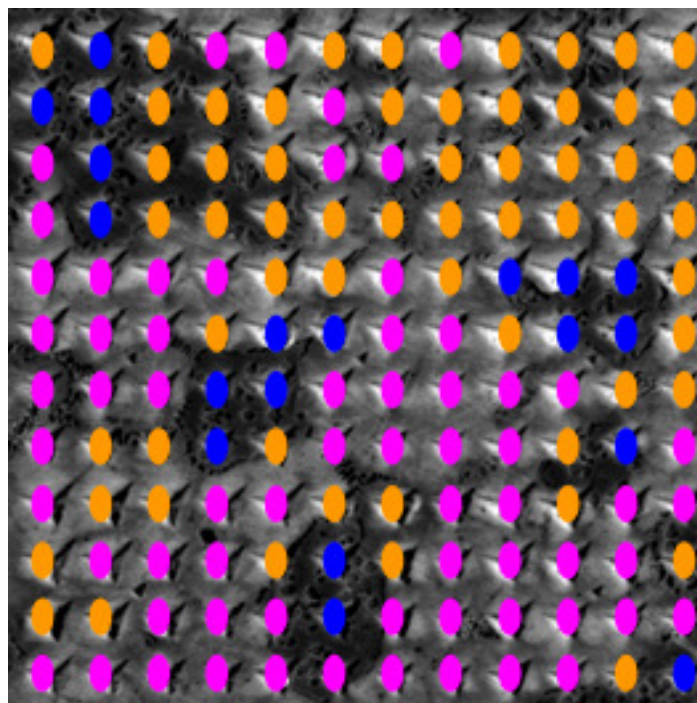
72% data usage: cluster 1 = Interface

RT



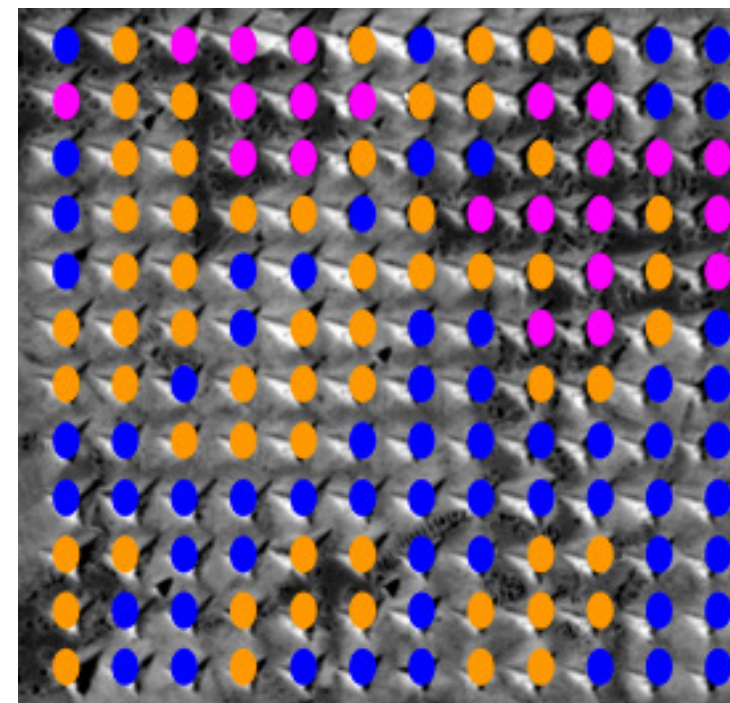
FCC: 4.0 ± 0.4 GPa
BCC: 6.1 ± 0.5 GPa

300°C



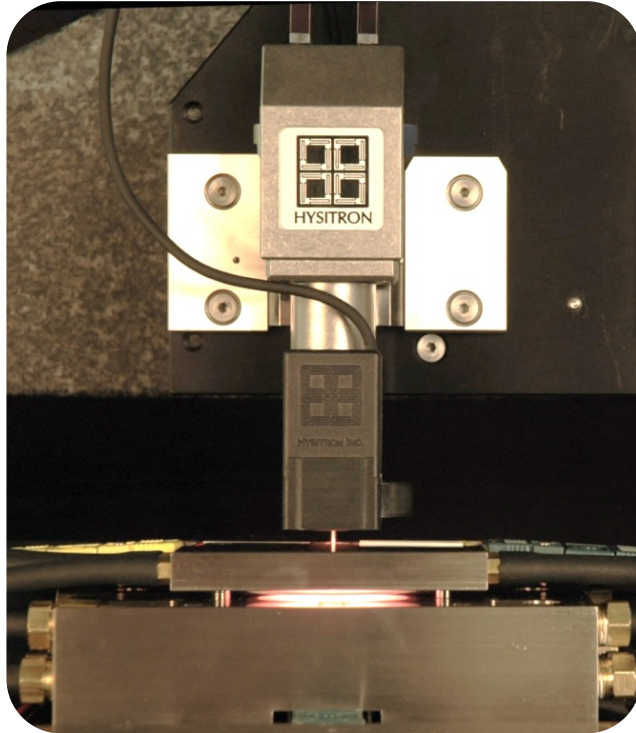
FCC: 3.6 ± 0.3 GPa
BCC: 5.6 ± 0.5 GPa

400°C

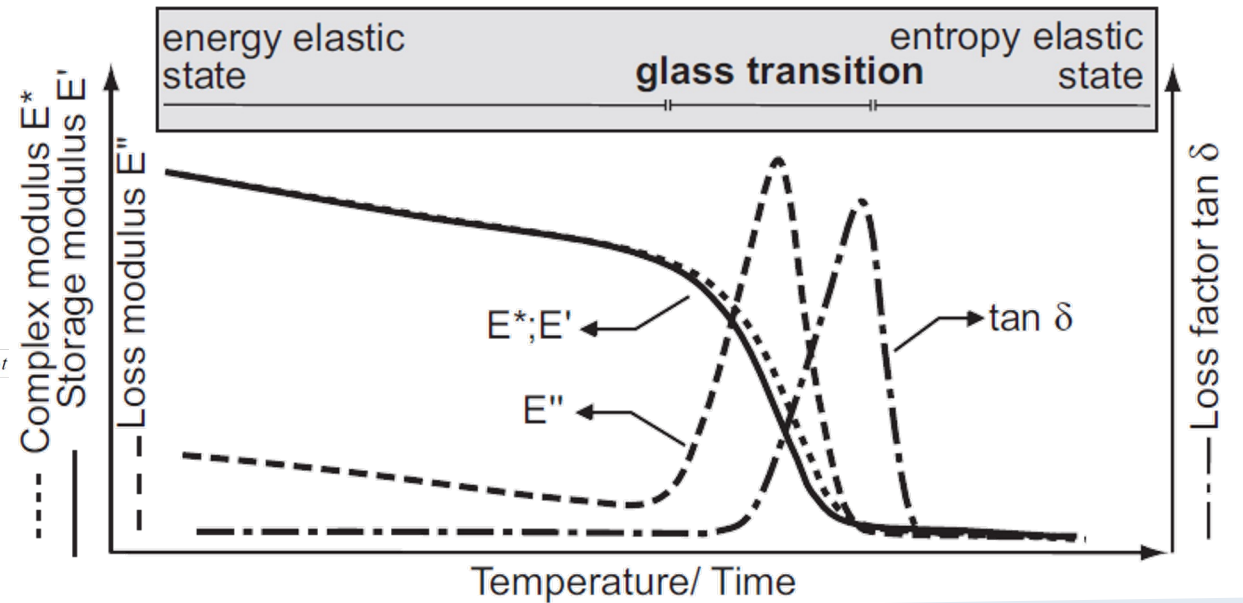
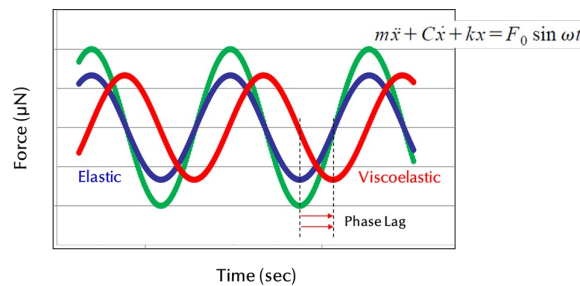
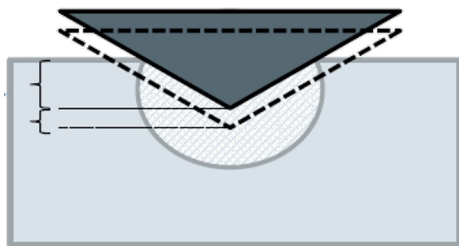


FCC: 3.6 ± 0.2 GPa
BCC: 5.5 ± 0.4 GPa

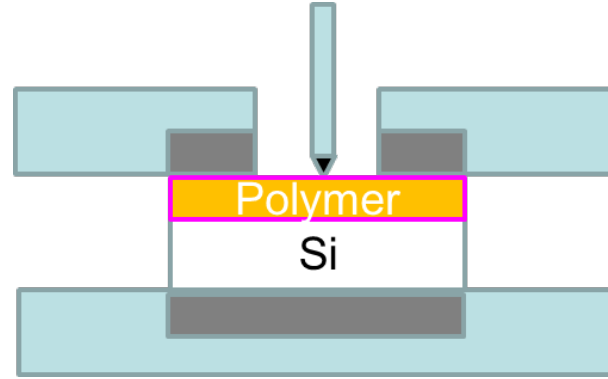
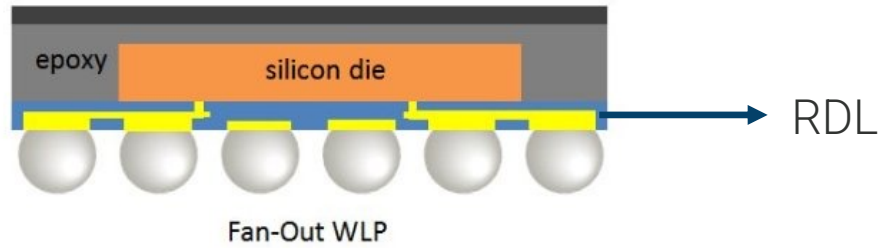
Technique for Glass Transition Temperature Measurements



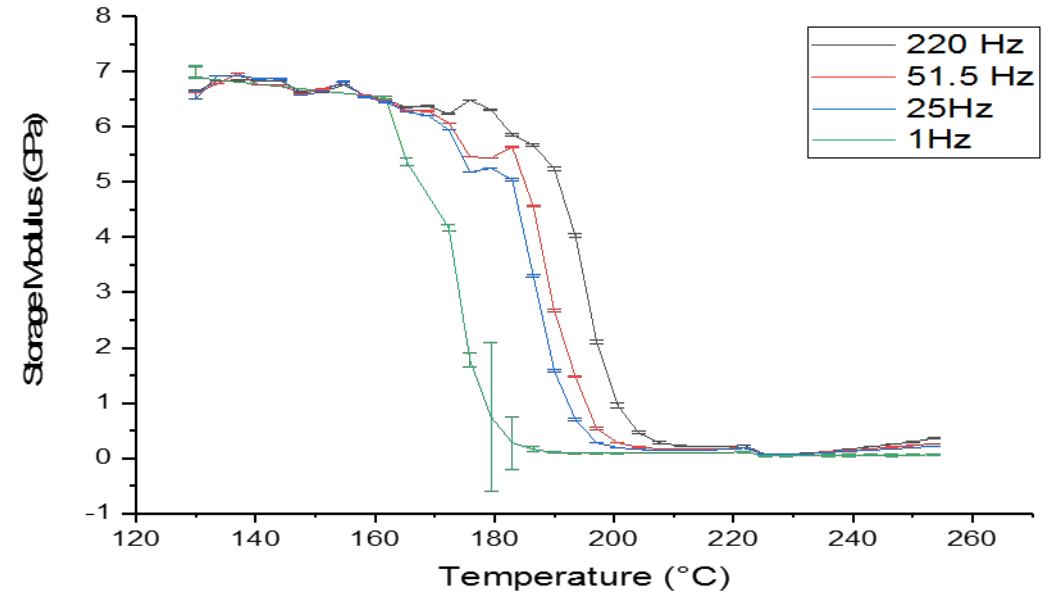
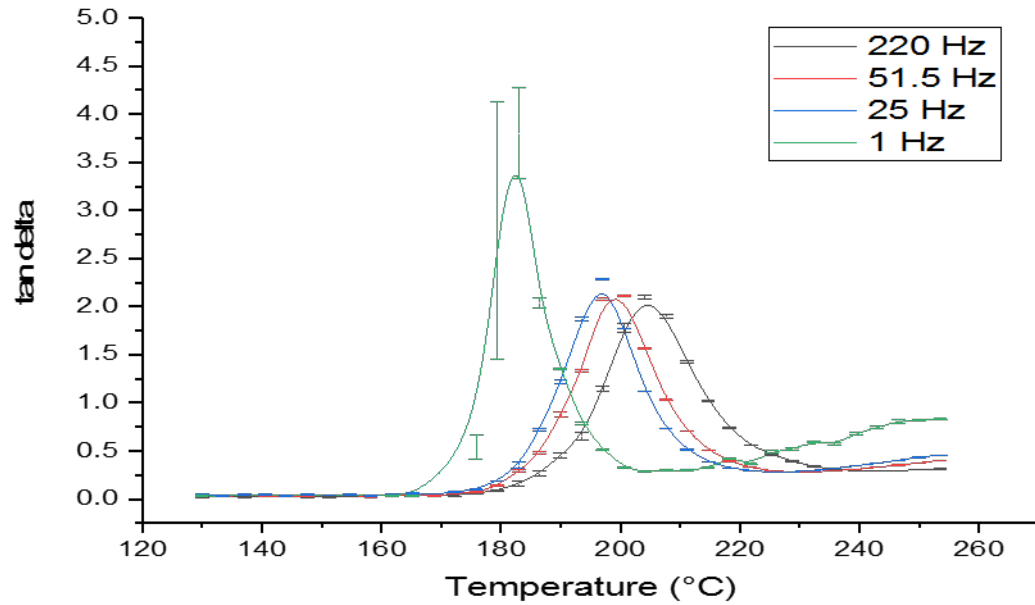
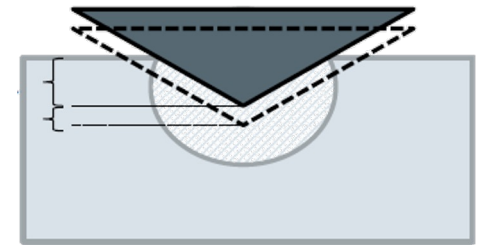
- Using automatically continuous DMA tests for Tg measurements is convenient for users.
- Compared to the rules using storage modulus, it is easy to apply the rule of tan-delta peak for determination of Tg.
- Practically, Tg determined by tan-delta peak is the end of glass transition.



Oscillation Frequency Effect on Tg Measurements



Nano-DMA

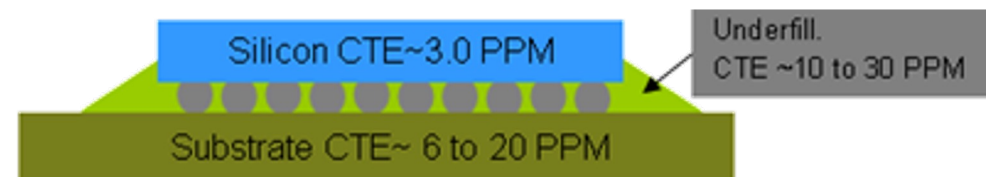


Overview of Linear Coefficient of Thermal Expansion

Material	CTE (ppm/°C)	Material	CTE (ppm/°C)
AlAs	4.9	InAs	4.52
AIP	4.5	InP	4.75
Alumina	6-7	InSb	5.37
AsSb	4	Invar	1.3
Copper	16.7	Kovar	5.9
Cu//Cu	8.4	Molybdenum	7.0-7.1
Cu/Mo/Cu	6	Polymers	50-200
Cu/Mo-Cu/Cu	6-10	S-glass	16
E-glass	54	Silicon	2.6
Epoxy	55	Silicon Nitride (Si ₃ N ₄)	3.2
Fused Silica	0.55	Silicone resins	30-300
Gallium Arsenide (GaAs)	6.86	Tin-Lead Solder	27
GaP	4.5	Titanium	9.5
GaSb	7.75	Tungsten	5.7-8.3
Germanium (Ge)	5.8		



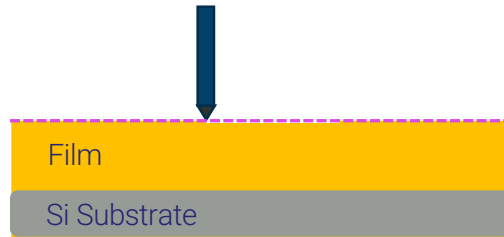
$$\frac{\Delta L}{L} = \alpha_L \Delta T$$



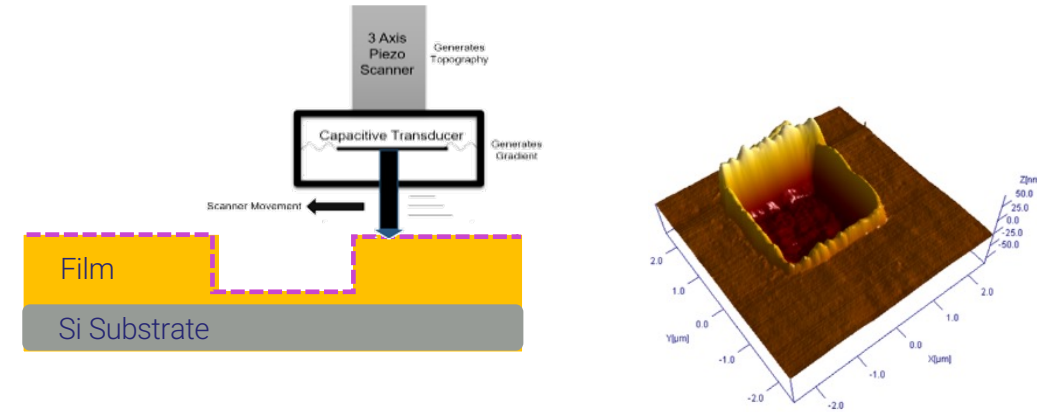
Solution for Thin Film's CTE Measurements

SPM Method

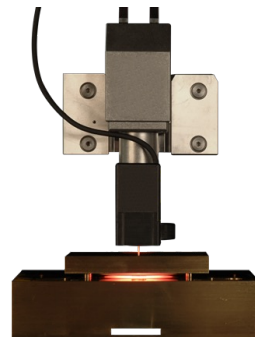
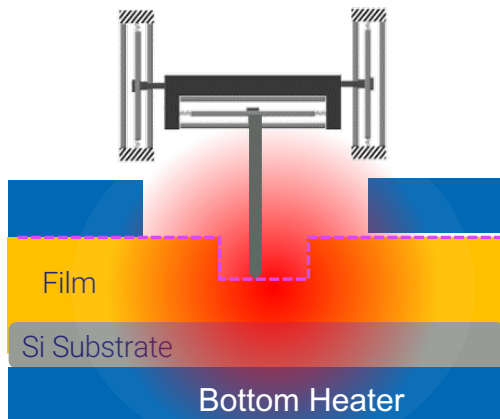
1. Nano Wear on the surface



2. SPM to measure the hole depth

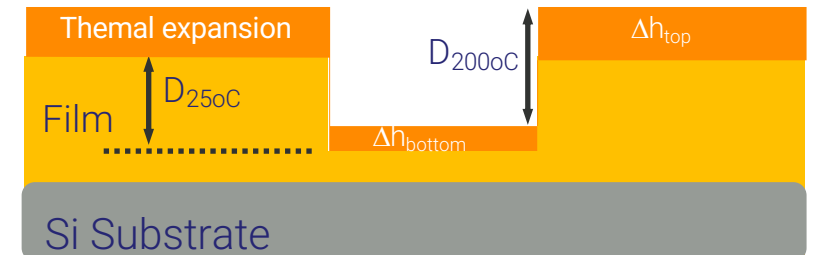


3. Heating the sample & SPM



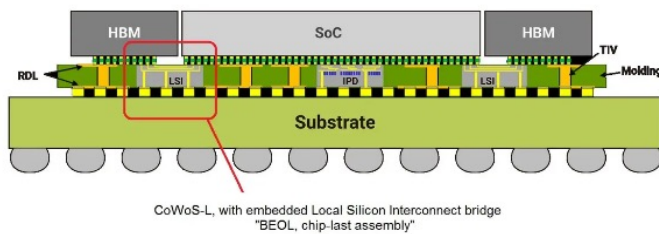
Hysitron xSol stage

4. SPM to measure the hole depth Changing



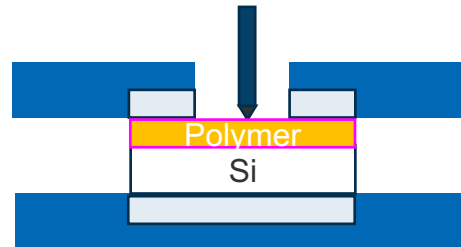
Thin PBO Film's CTE Measurements

SPM Method



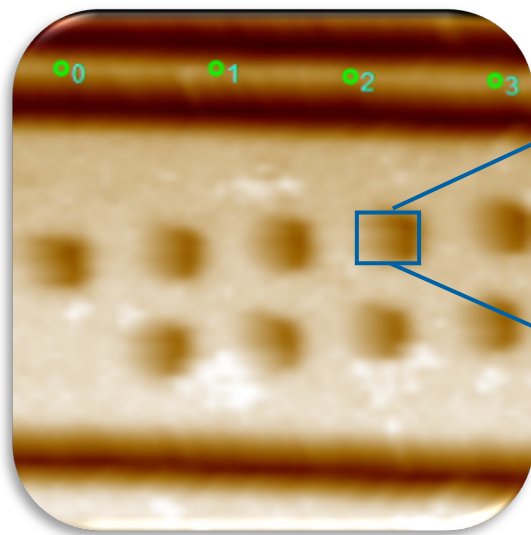
CoWoS-L, with embedded Local Silicon Interconnect bridge "BEOL, chip-last assembly"

<https://semiwiki.com/>

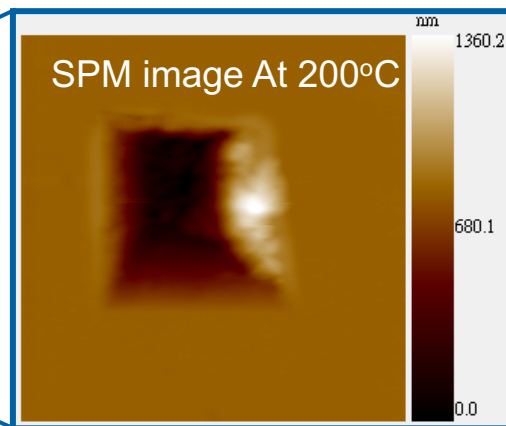


Advantages:

- Direct measurements
- High spatial resolution



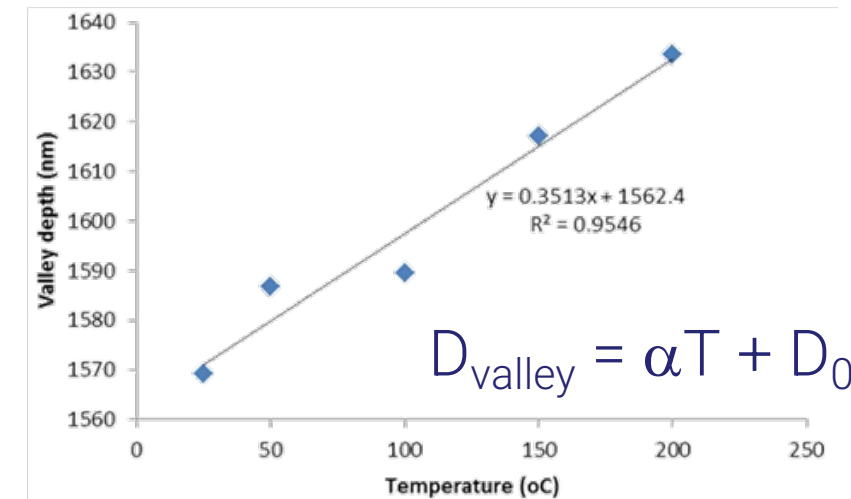
Post-wear images of polymer film



Whole Image Statistics

Projected Area	= 400 ȳ²
RMS Roughness (Rq)	= 179.149 nm
Average Roughness (Ra)	= 107.798 nm
Mean Height	= -52.4029 nm
Max Height	= 580.534 nm
Min Height	= -847.151 nm
Peak-to-Valley	= 1427.68 nm

Valley depth increasing from 838.3nm to 847.2nm form 25oC – 200 oC



$$D_{\text{valley}} = \alpha T + D_0$$

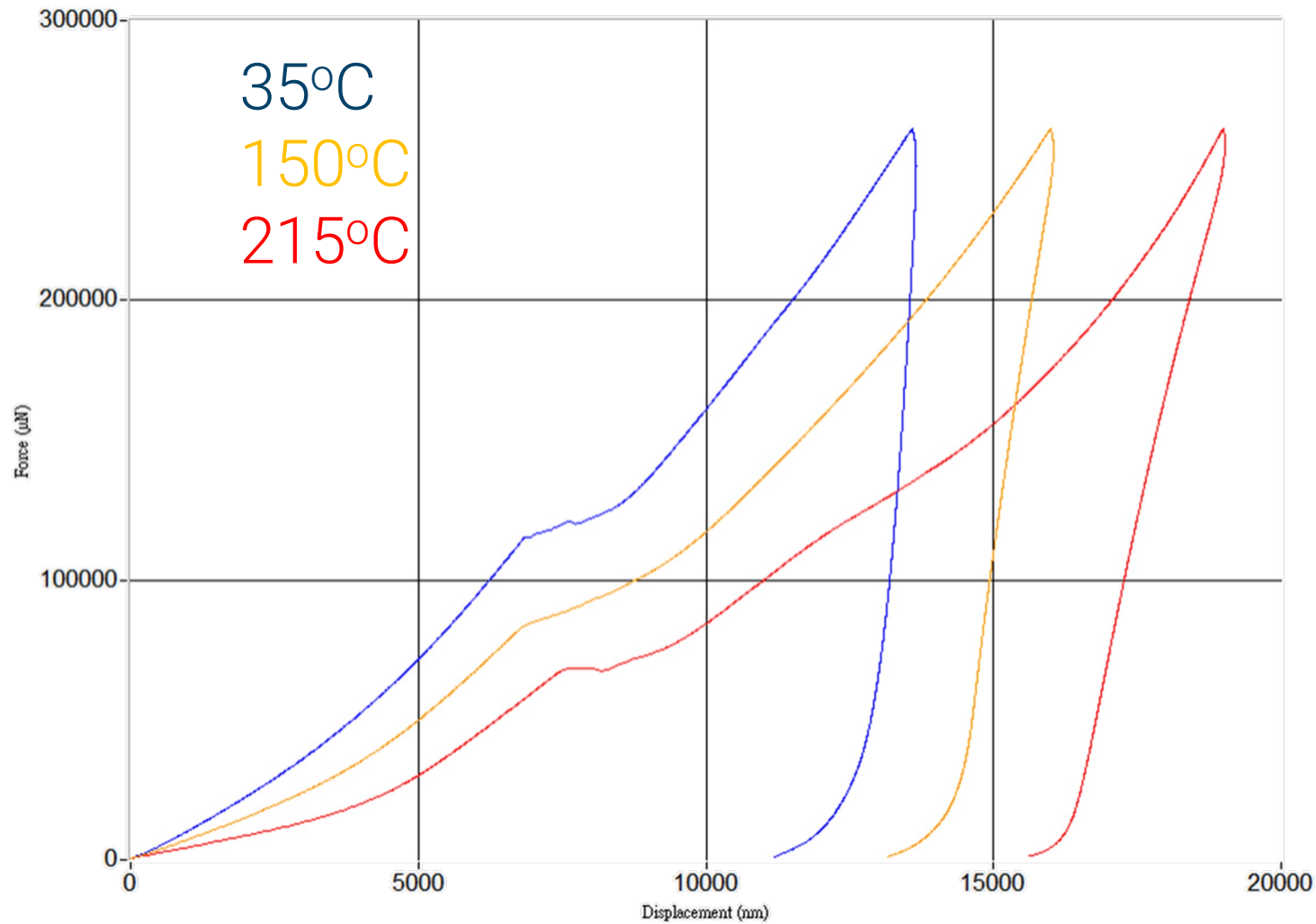
$$\text{CTE} = \alpha / D_0$$

$$= 0.3513(\text{nm}/^\circ\text{C}) / 1562.4(\text{nm})$$

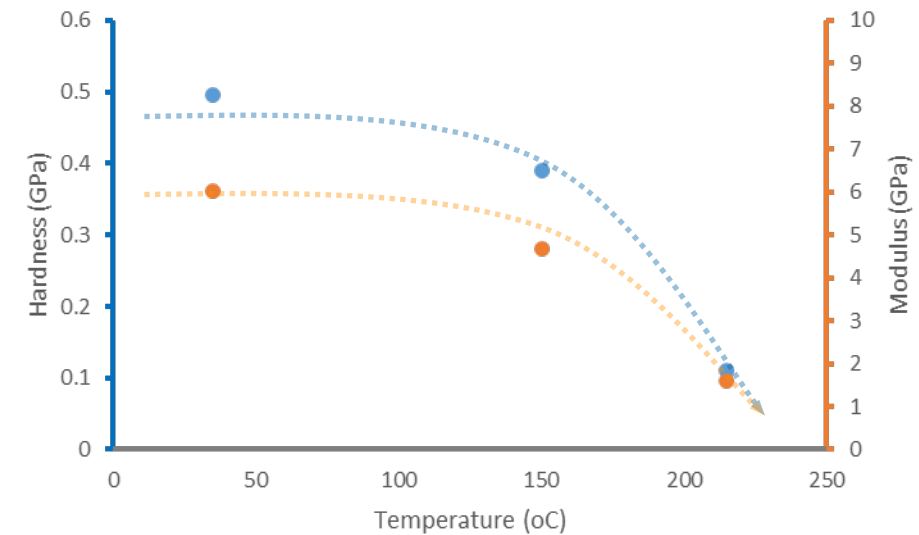
$$= 224.8\text{ppm}/^\circ\text{C}$$

High Load Indentations at Elevated Temperature

Polymer Film on Copper

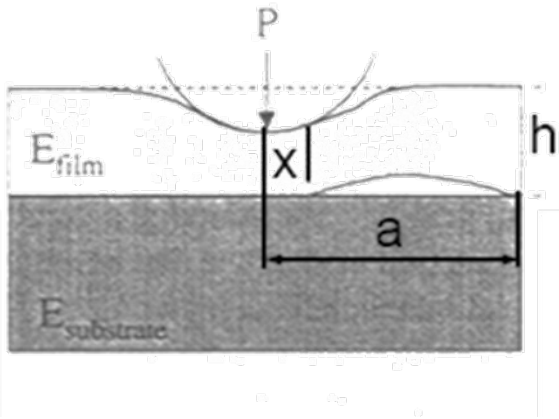


T (°C)	L _{crit} (uN)	H (GPa)	E (GPa)
35	115218.2	0.4963	6.02
150	84091.46	0.3906	4.69
215	68276.05	0.1101	1.59



Adhesion Work Calculation at Temperature Levels

Polymer Film on Copper



Developed by Rosenfeld et al. (1990)

Film hardness

Film thickness

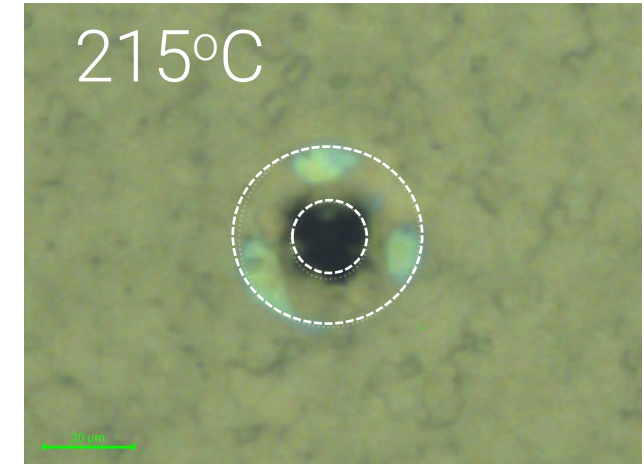
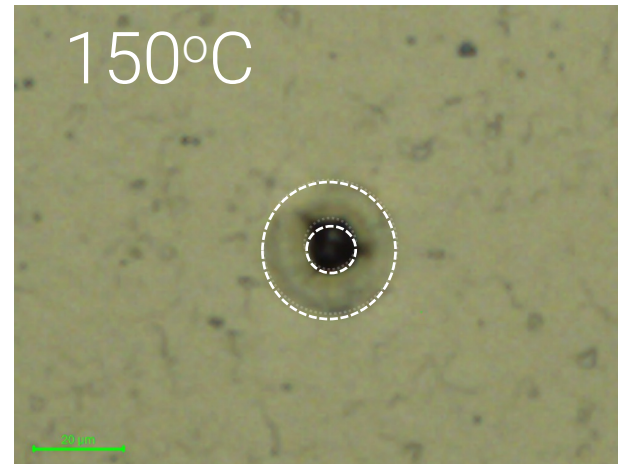
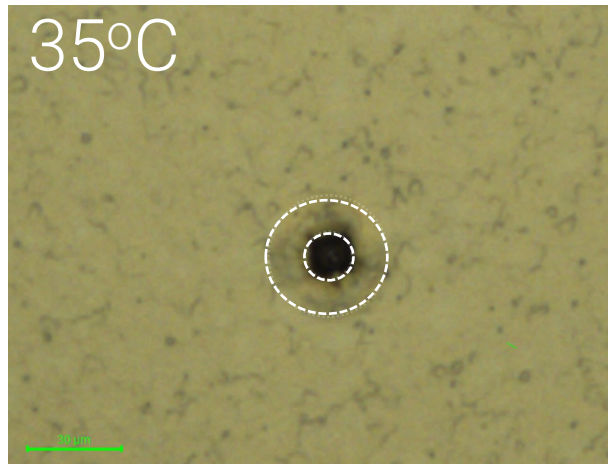
$$G = \frac{0.627H^2h(1-\nu_f^2)}{E_f} \left(\frac{1}{1 + \nu_f + \underbrace{(a/x)^2}_{\text{Delaminated radius}}(1-\nu_f)} \right)^2$$

Delaminated radius

Contact radius

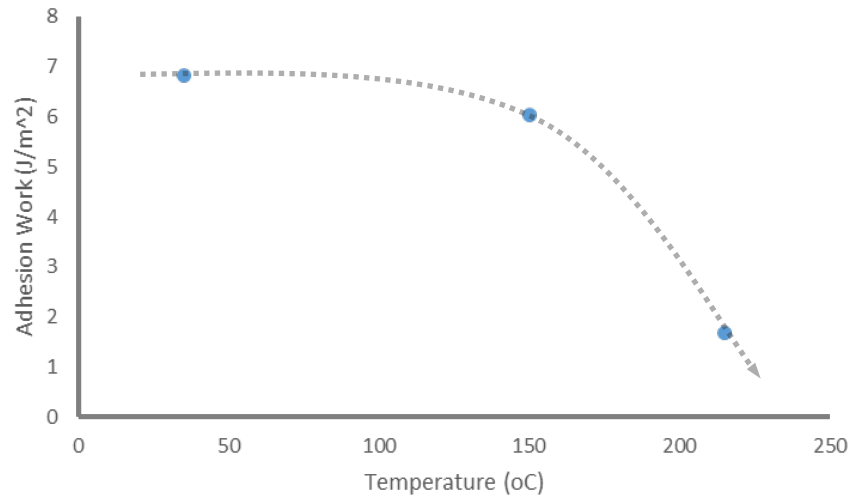
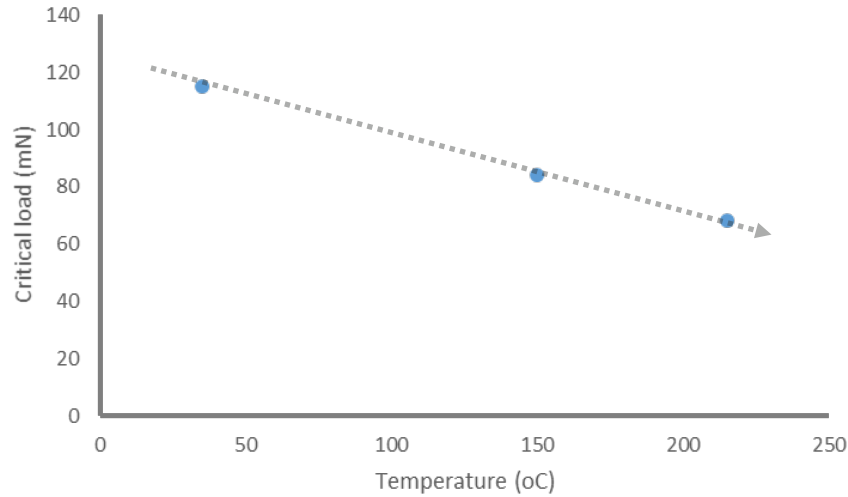


3D Omniprobe
2N ,10 N with 80 um

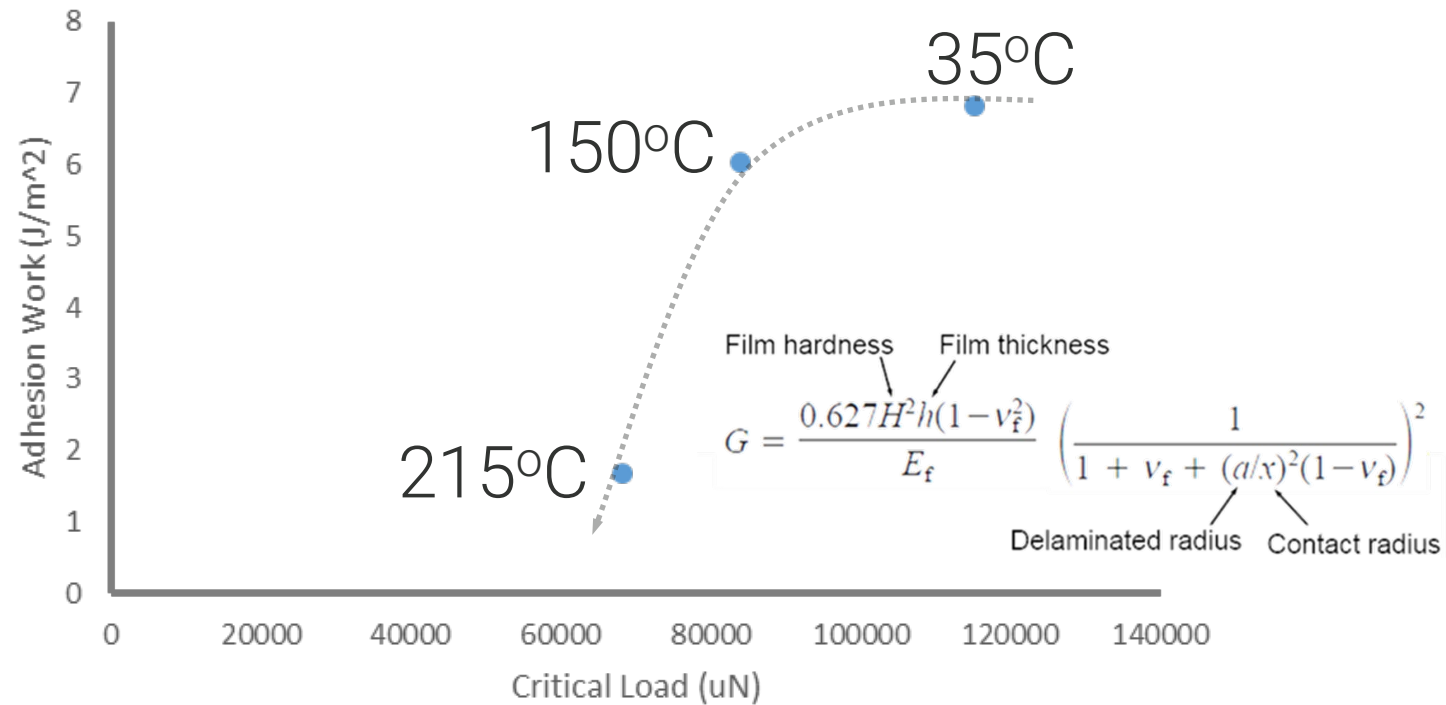


Adhesion Work Calculation at Temperature Levels

Polymer Film on Copper

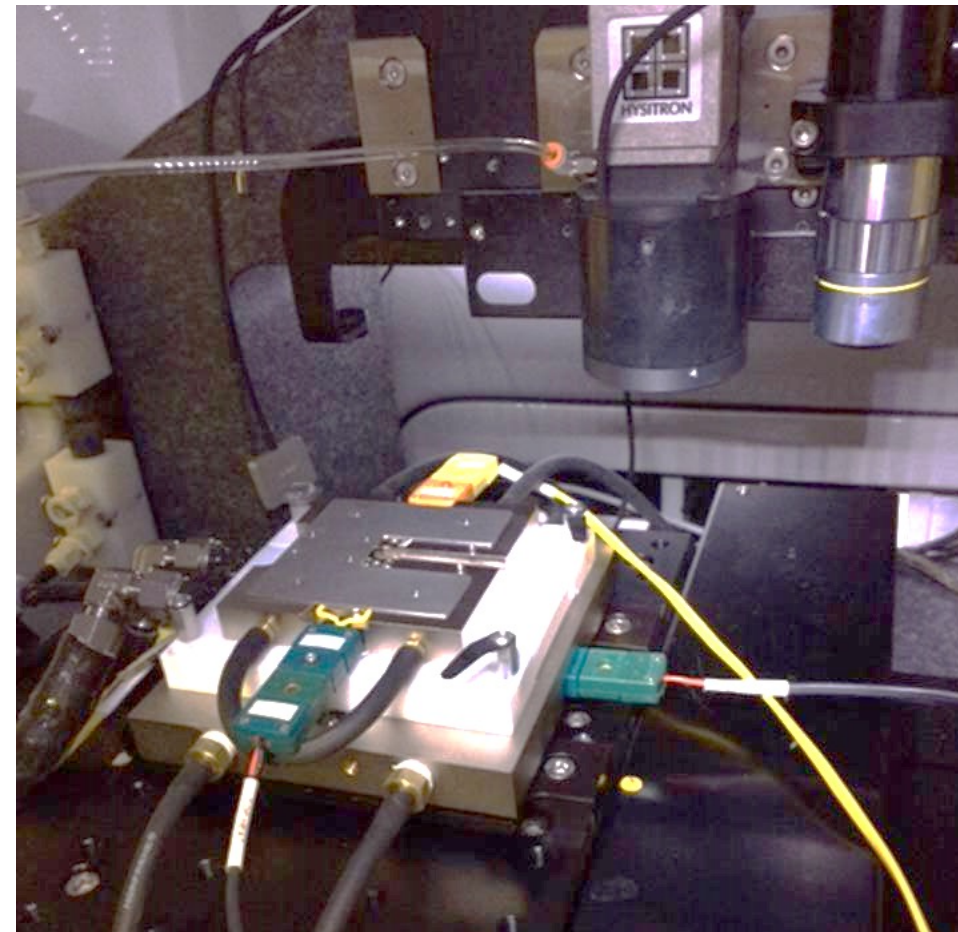


H (GPa)	T (°C)	E (GPa)	Lcrit (uN)	G (J/m ²)
0.49	35	6.02	115218.2	6.81
0.39	150	4.69	84091.5	6.04
0.11	215	1.59	68276.1	1.68



Applications at Low Temperature

xSol Cooling Stage System Overview

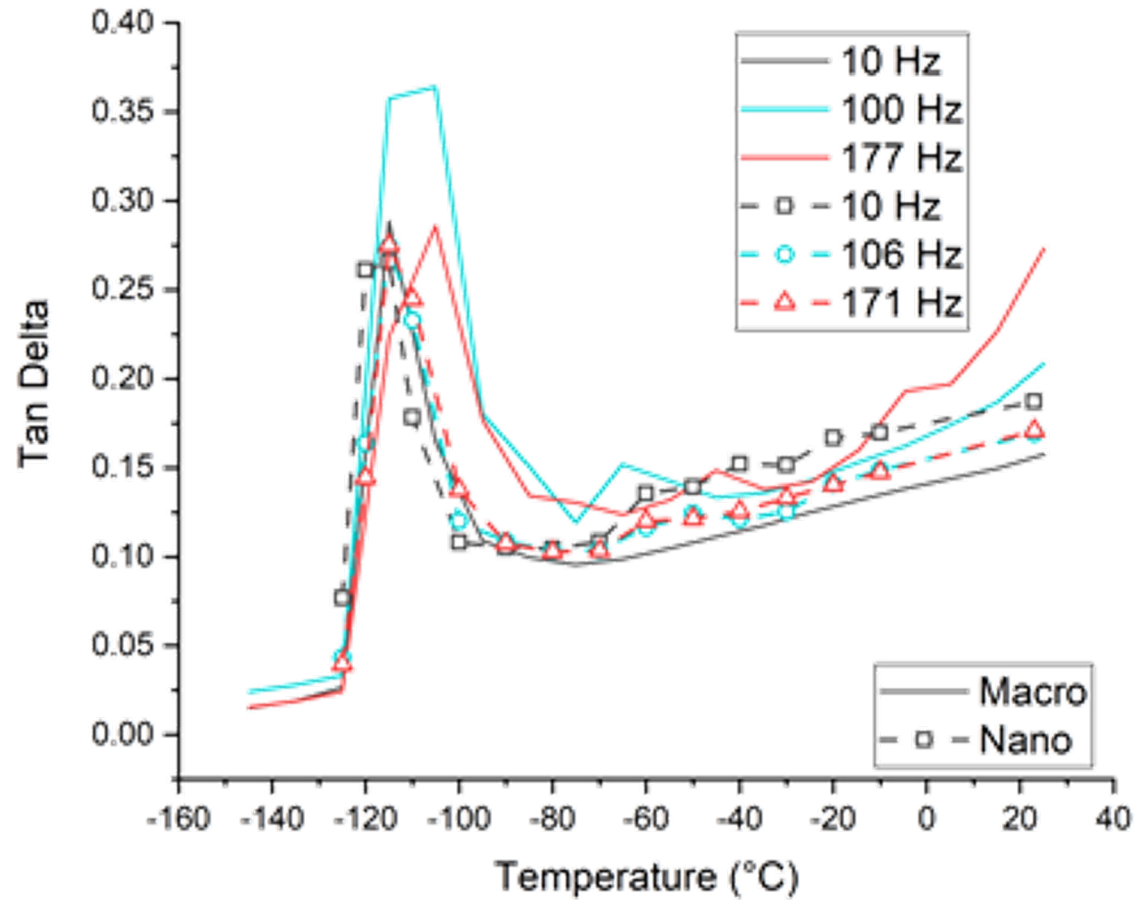
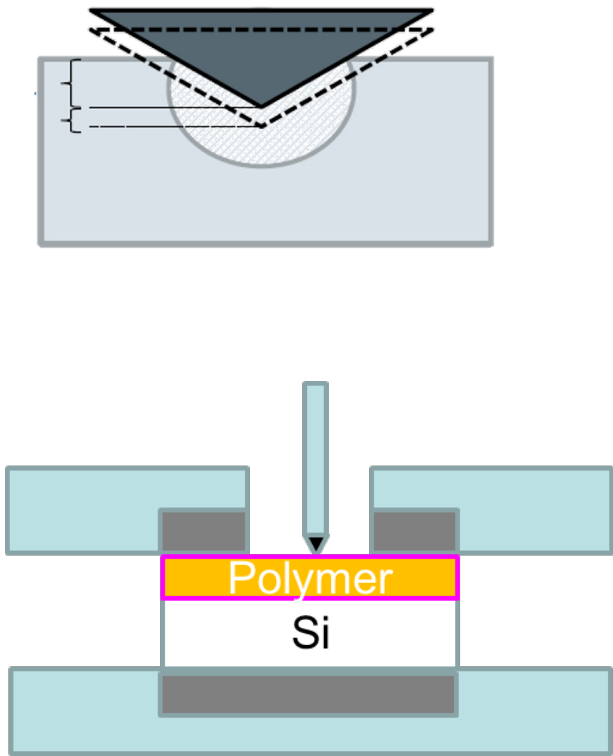


- Nitrogen gas passes through liquid N₂ to cool
- Cold gas enters the chamber through a port on the side of the enclosure to passively cool the chamber
- A heater is used to actively hold the temperature steady at the set temperature
- Achieves cooling capabilities down to -160°C

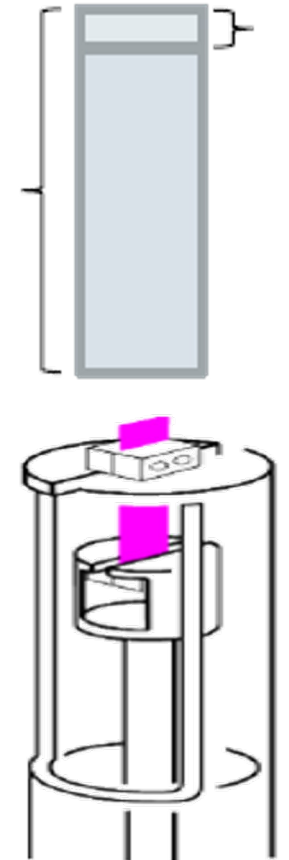
Internal heat exchanger/sample chamber

Comparisons between Nano and Macro: Frequency Effects on 500um PDMS

Nano-DMA

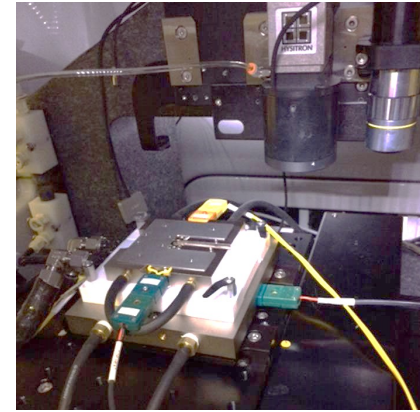
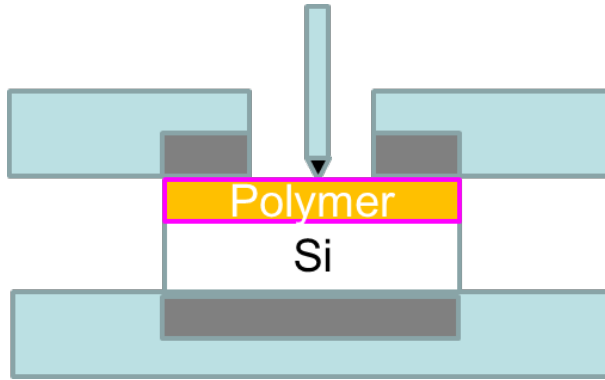
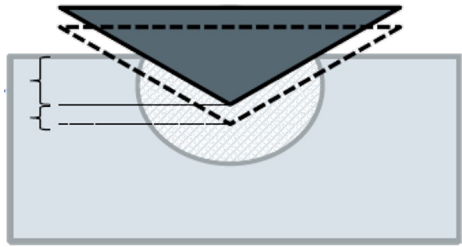


Macro-DMA



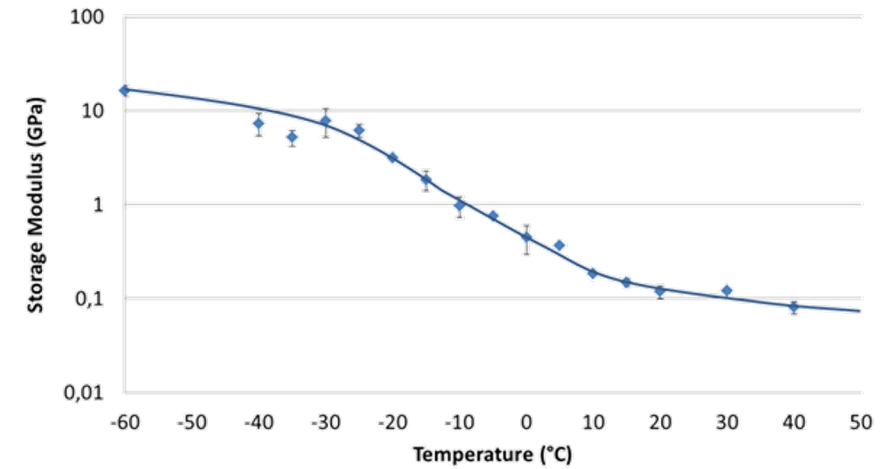
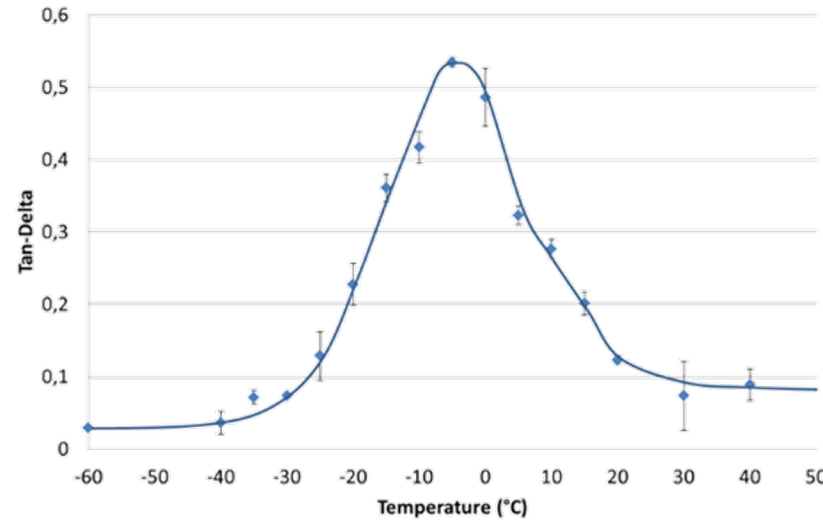
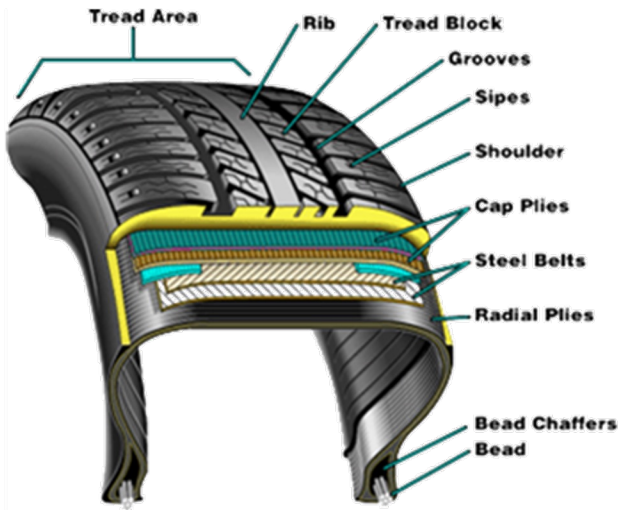
Source: TA instrument

xSol Heating & Cooling on Tire Rubber

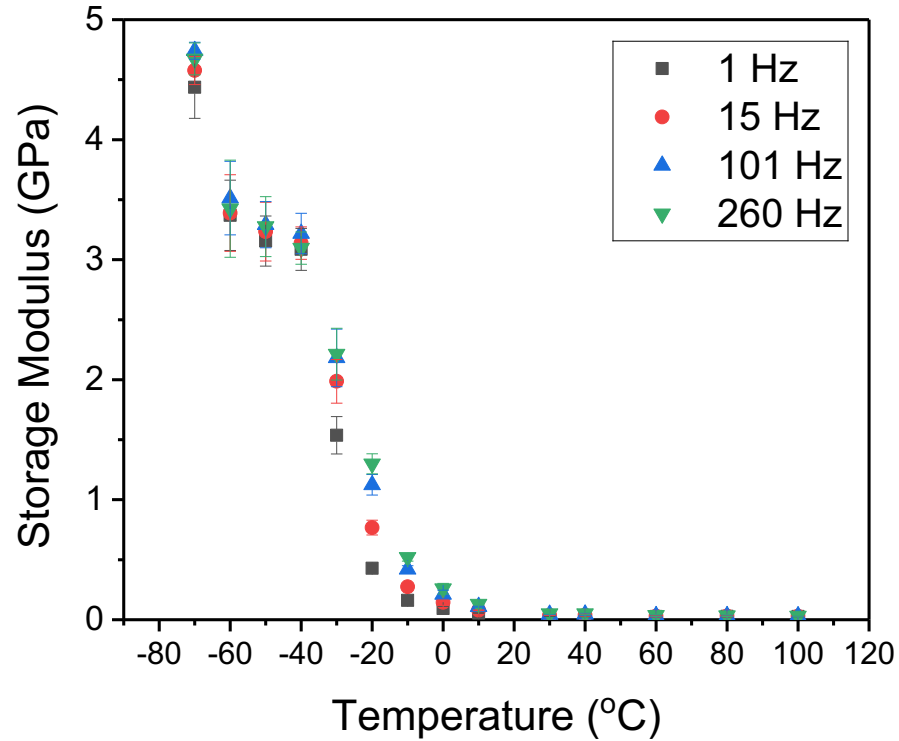


Tan-Delta

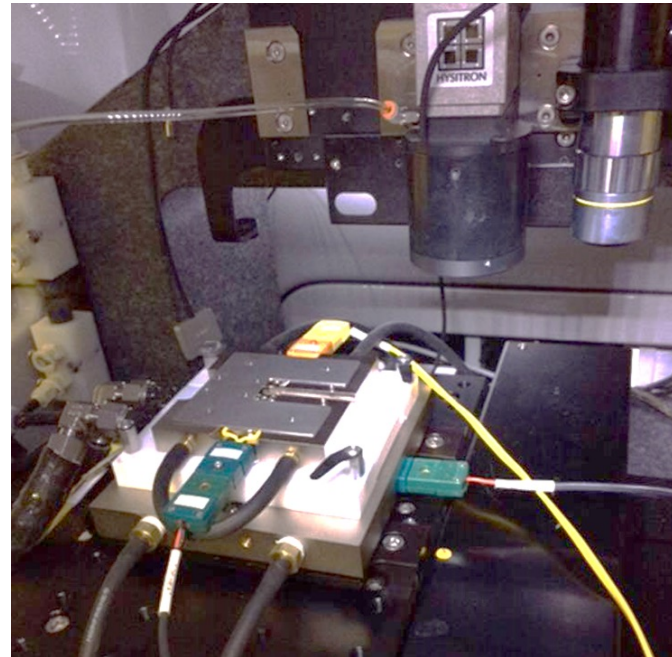
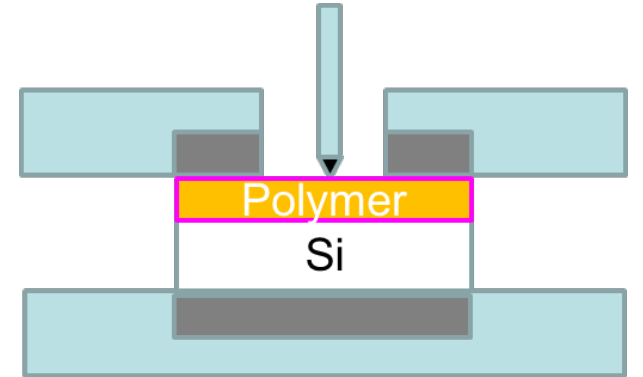
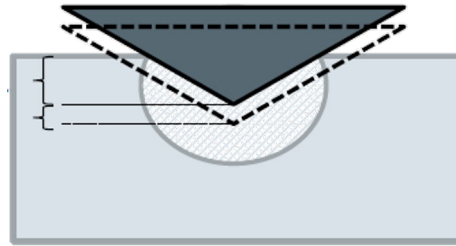
Reference Storage Modulus



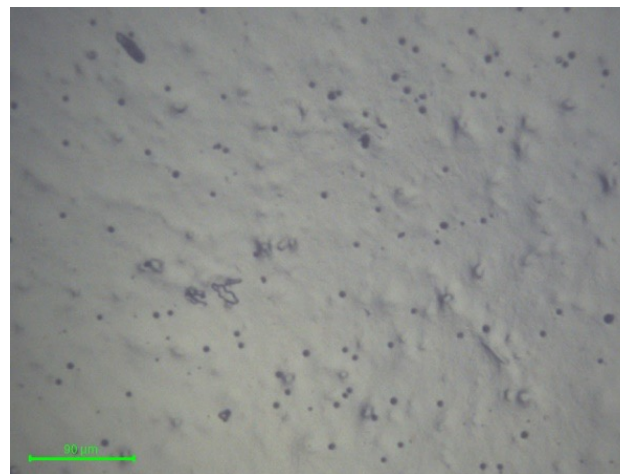
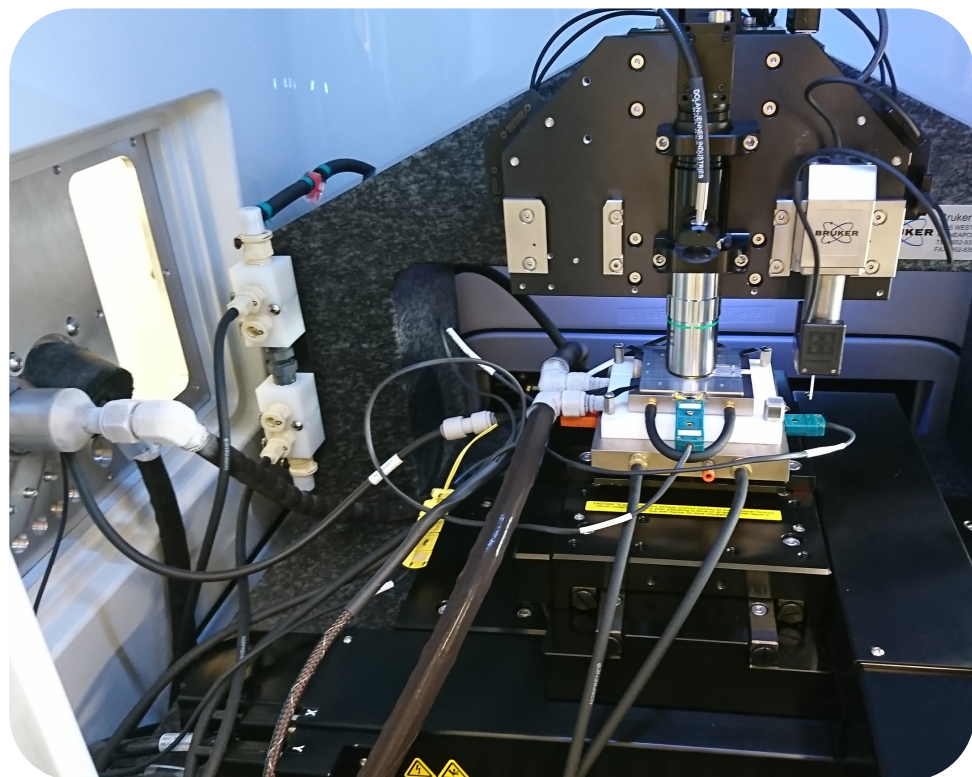
Low Temperature Testing of Polymer Films



10µm thick polymer film



Two 'Over The Counter' Adhesives



Adhesive 1

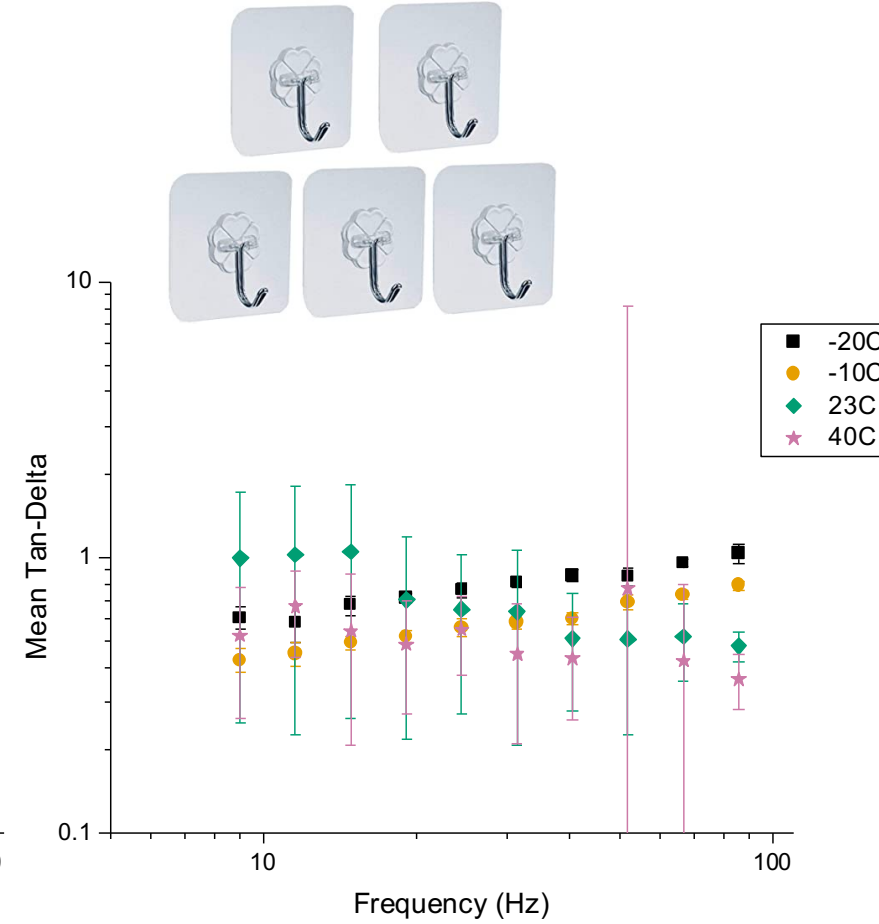
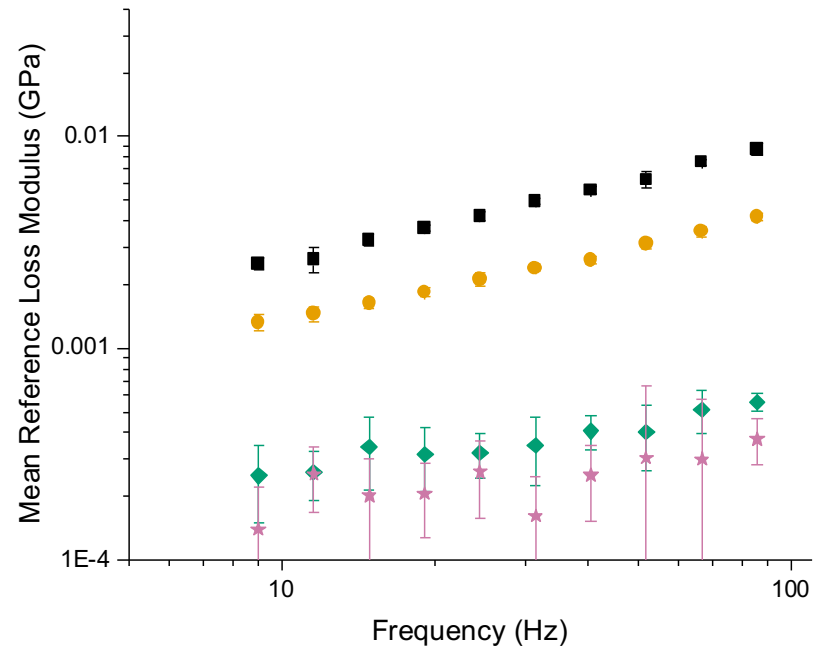
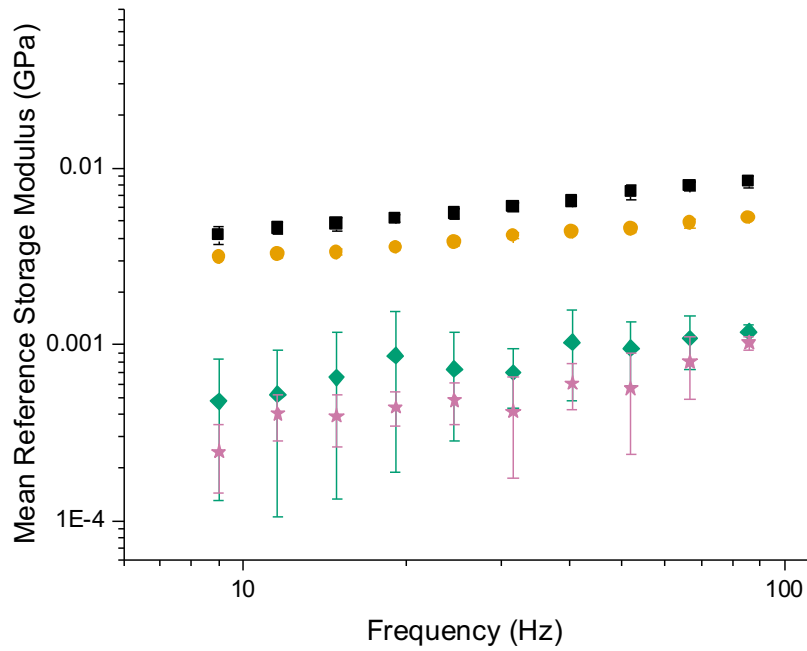
'wall sticky'



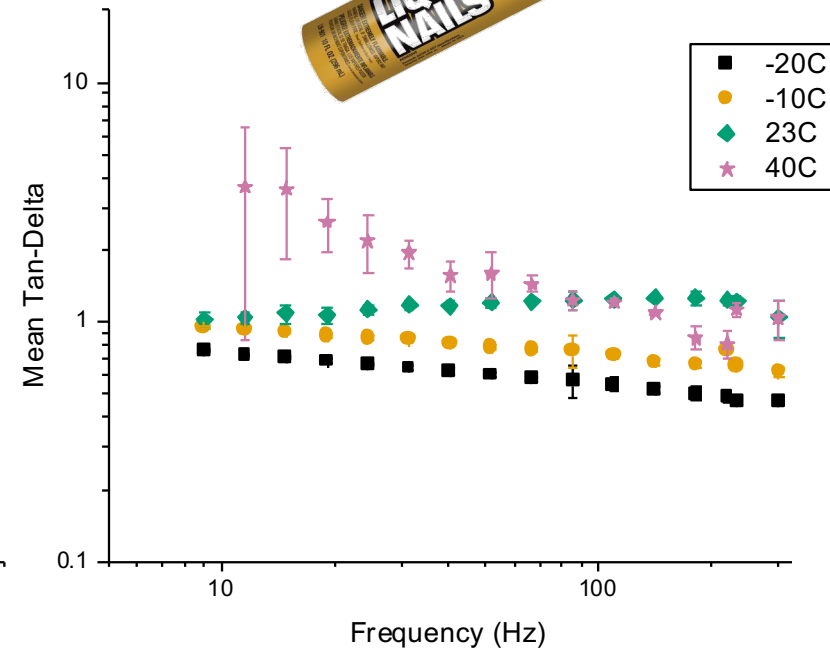
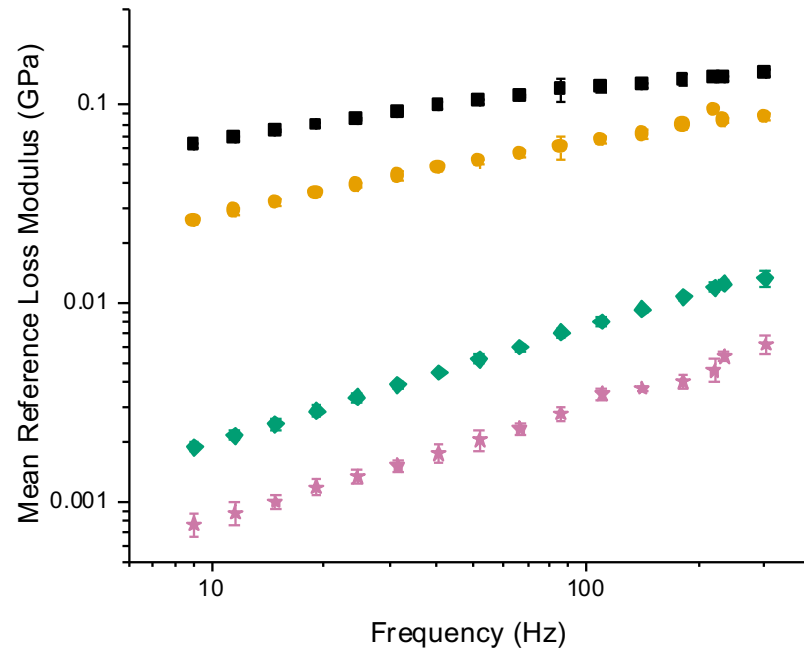
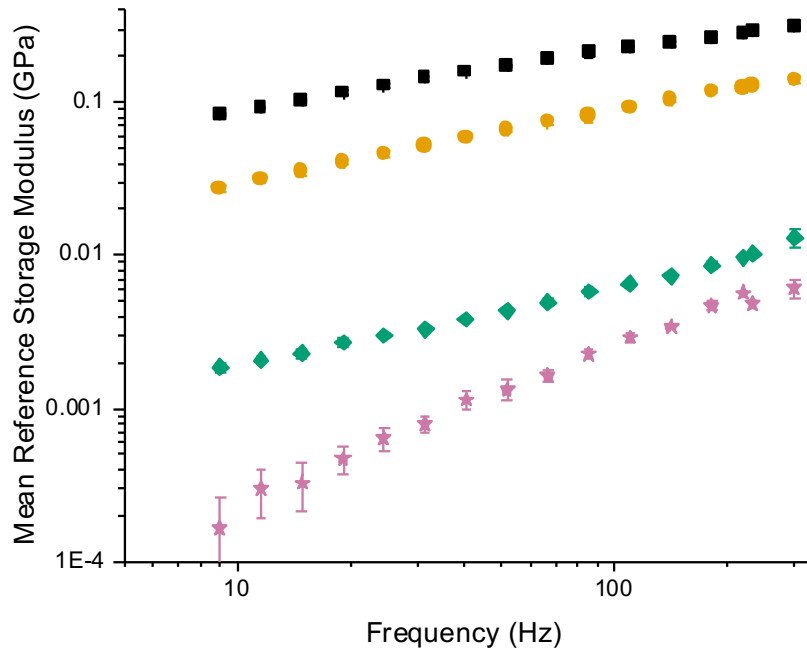
Adhesive 2

'construction'

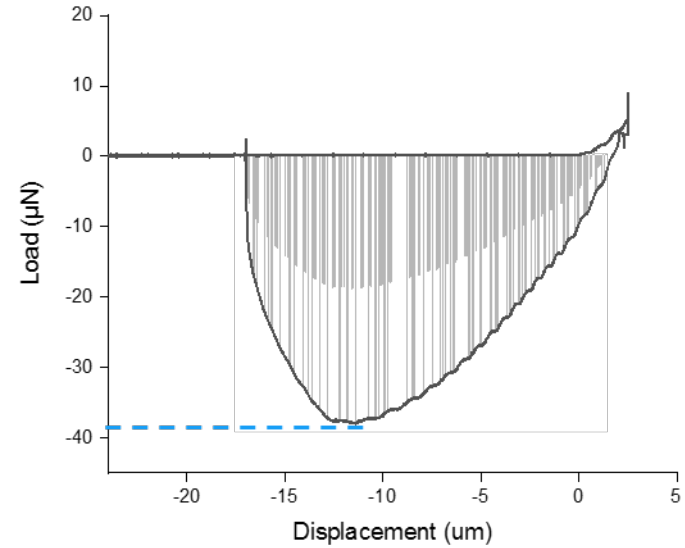
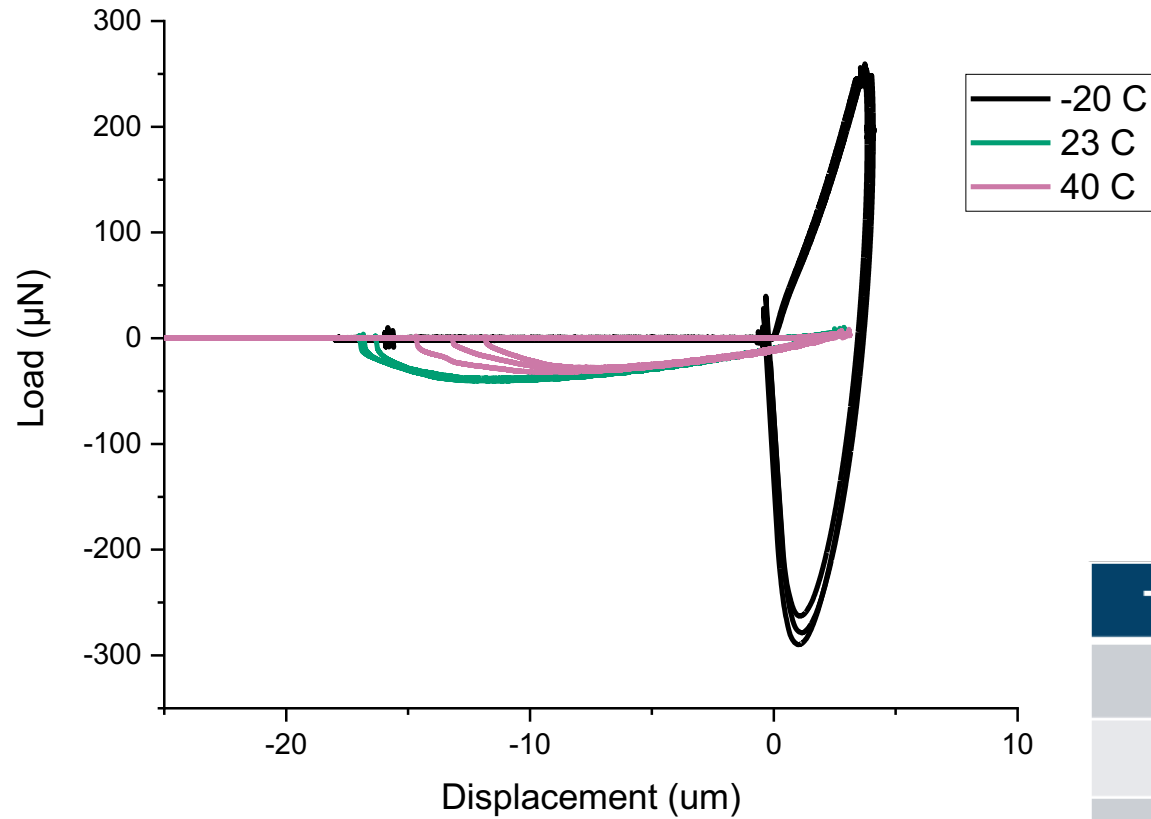
Adhesive 1 - Wall Sticky



Adhesive 2 – ‘Construction’



Adhesive 2 – ‘construction’ Measuring adhesion

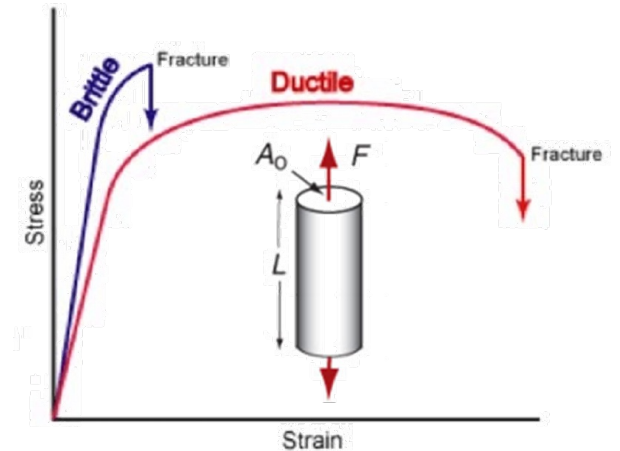
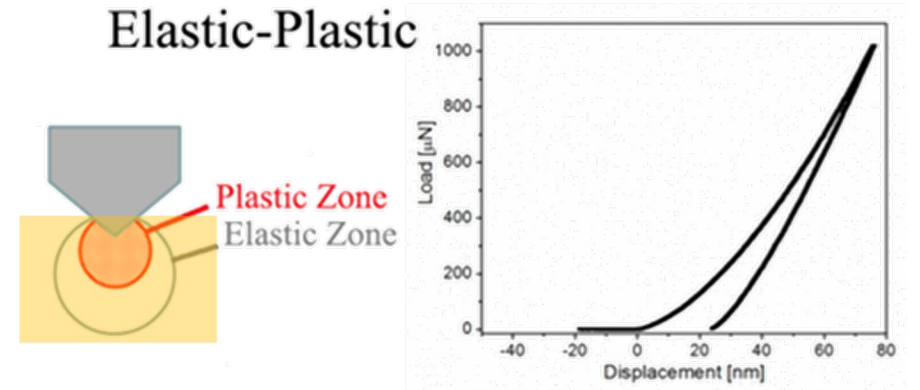
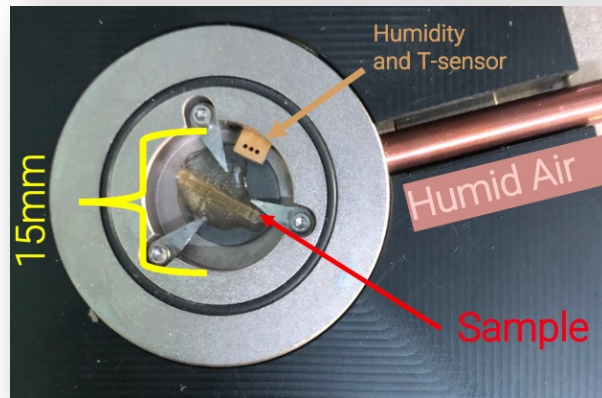
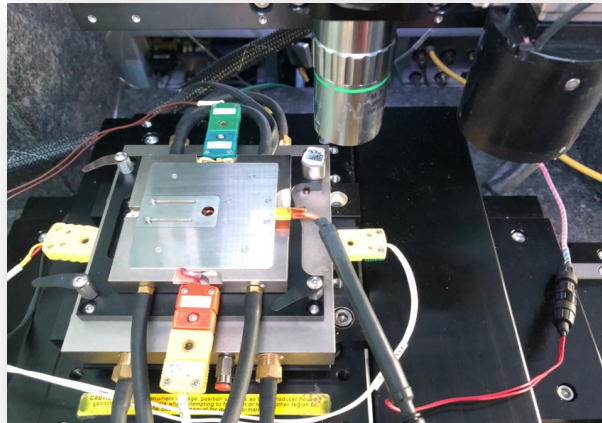


Temperature (°C)	Pull –off Force (uN)	Work (uJ)
-20	-276.97±13.41	378.59±16.49
23	-39.55±1.30	232.82±4.71
40	-29.73±2.17	151.98±28.46

Applications at Humidity Levels

xSol[®] Humidity Control

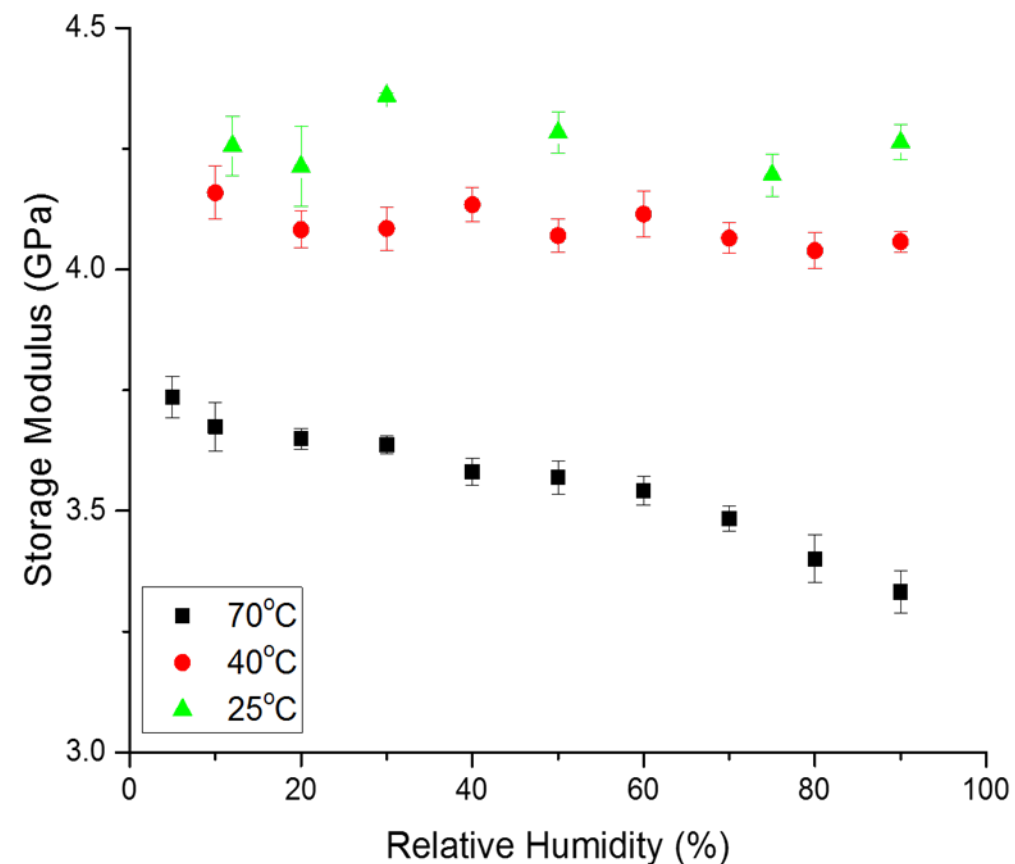
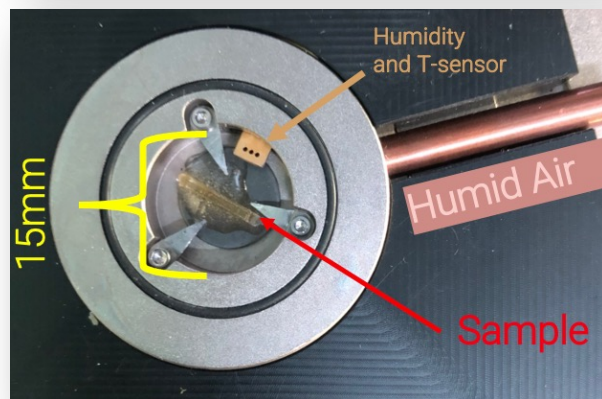
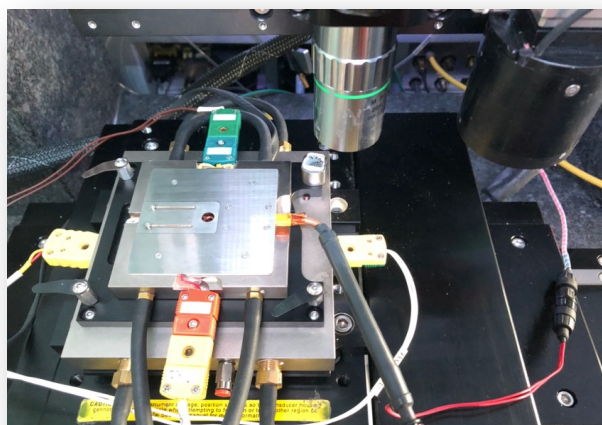
Humidity, Temperature, Mechanical Property Results of a Polymer Film



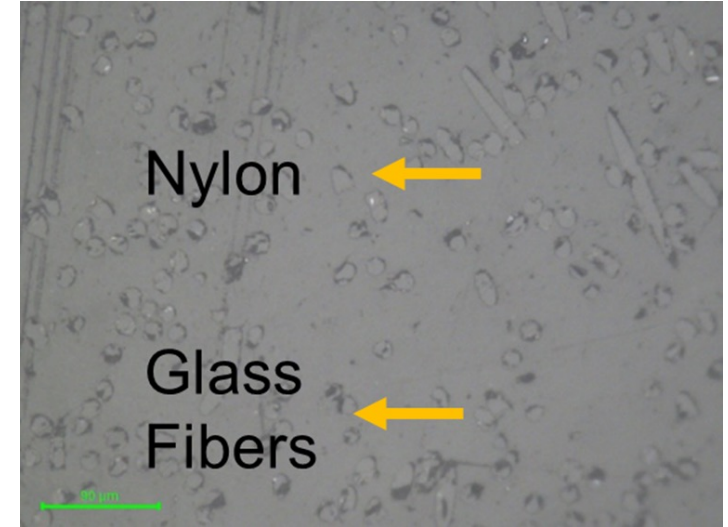
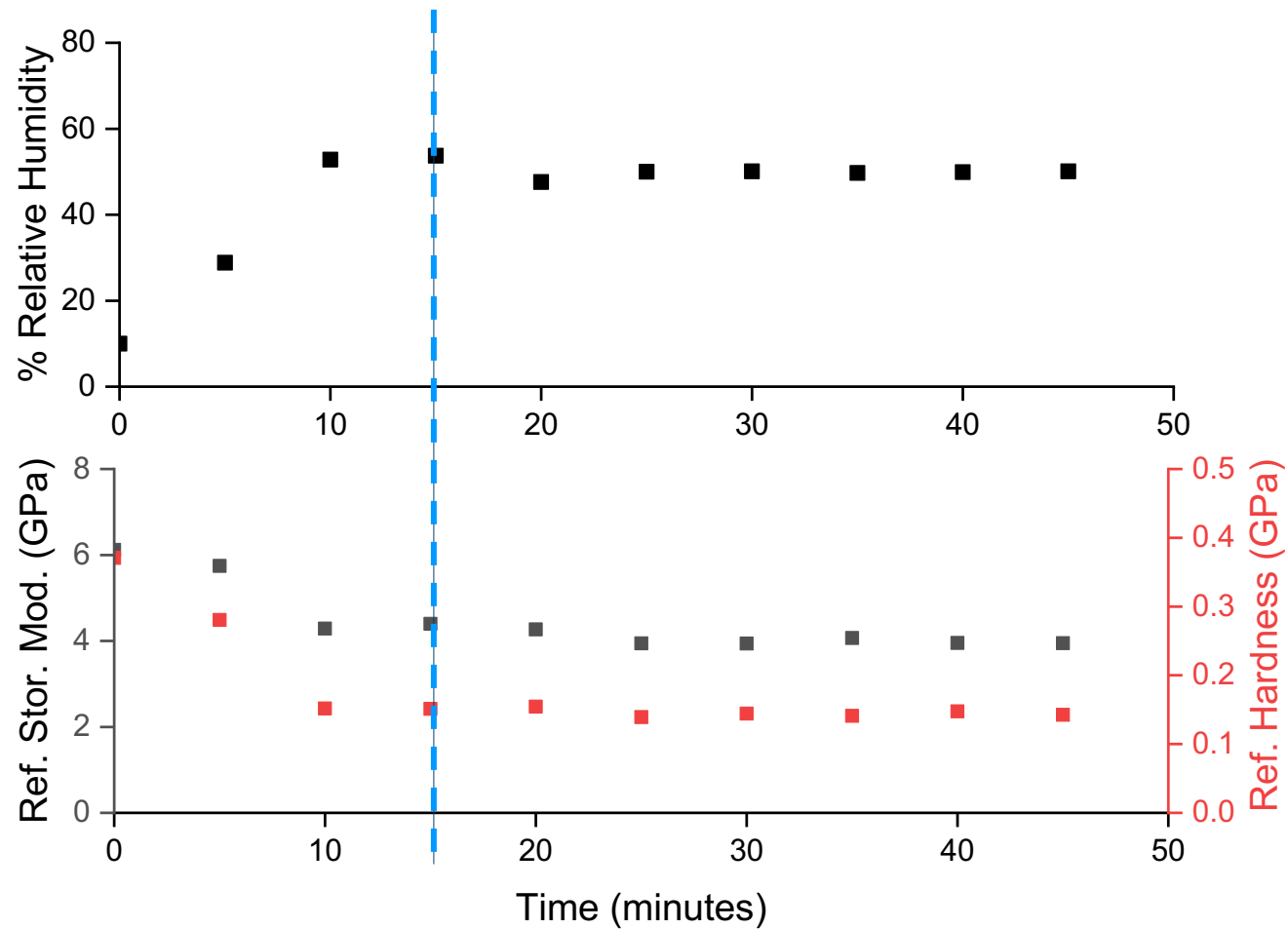
<https://sites.google.com/site/polymorphismmyhomepage/investigating-material-failures>

xSol[®] Humidity Control

Humidity, Temperature, Mechanical Property Results of a Polymer Film

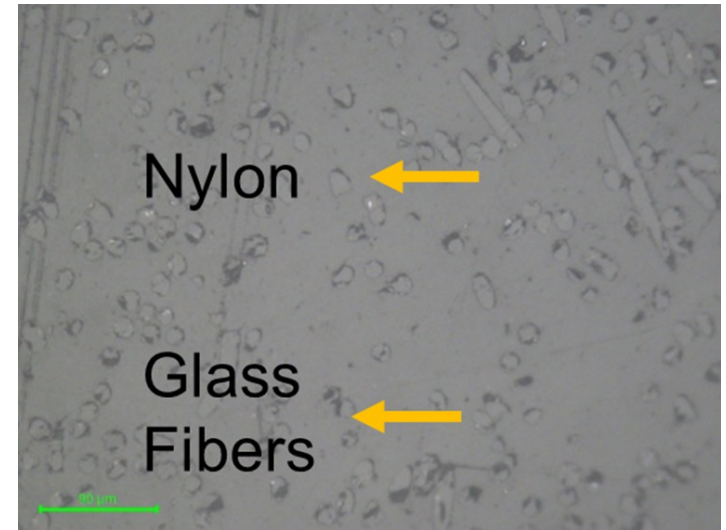
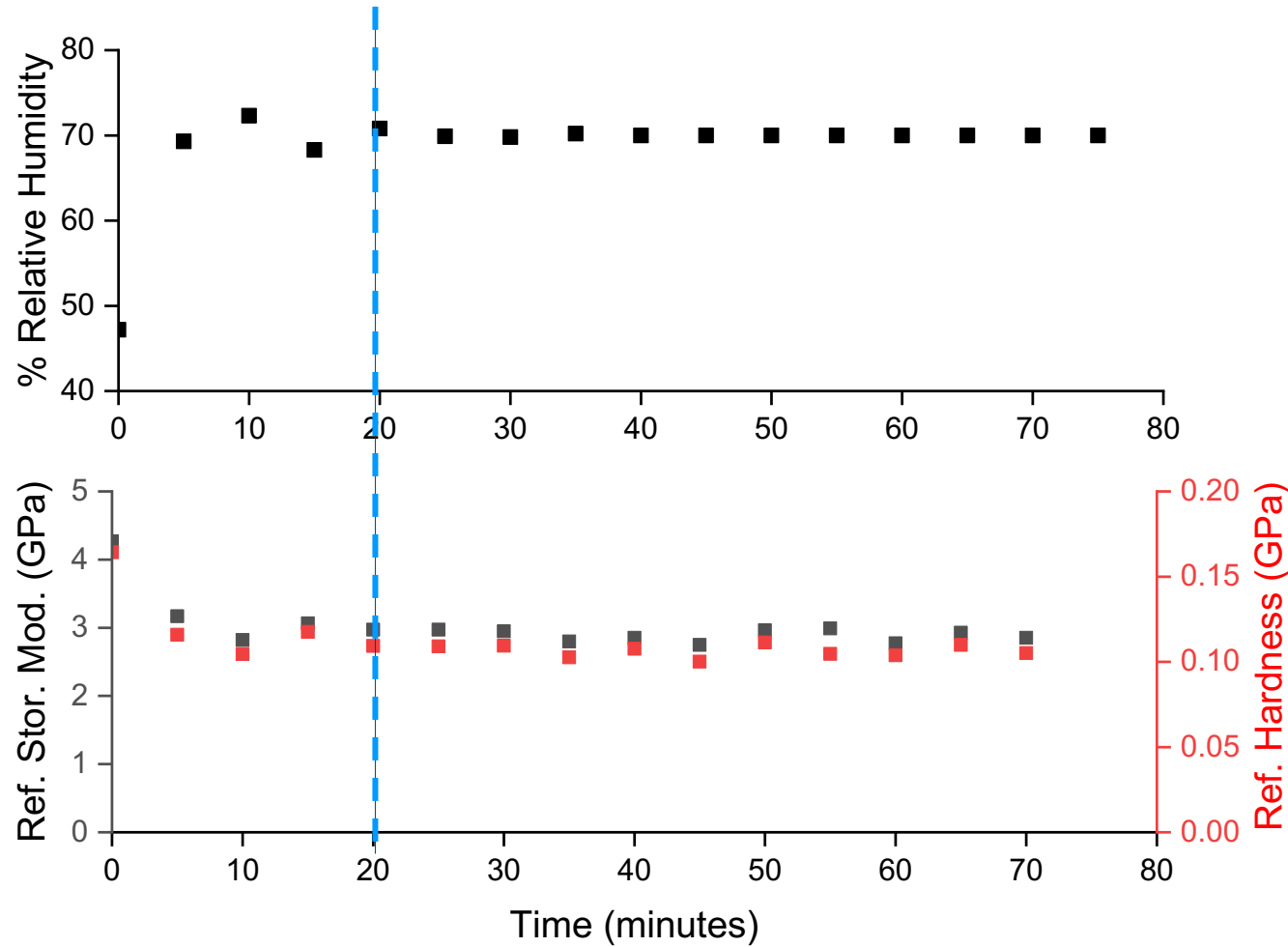


Humidity Testing of Glass Filled Nylon 66



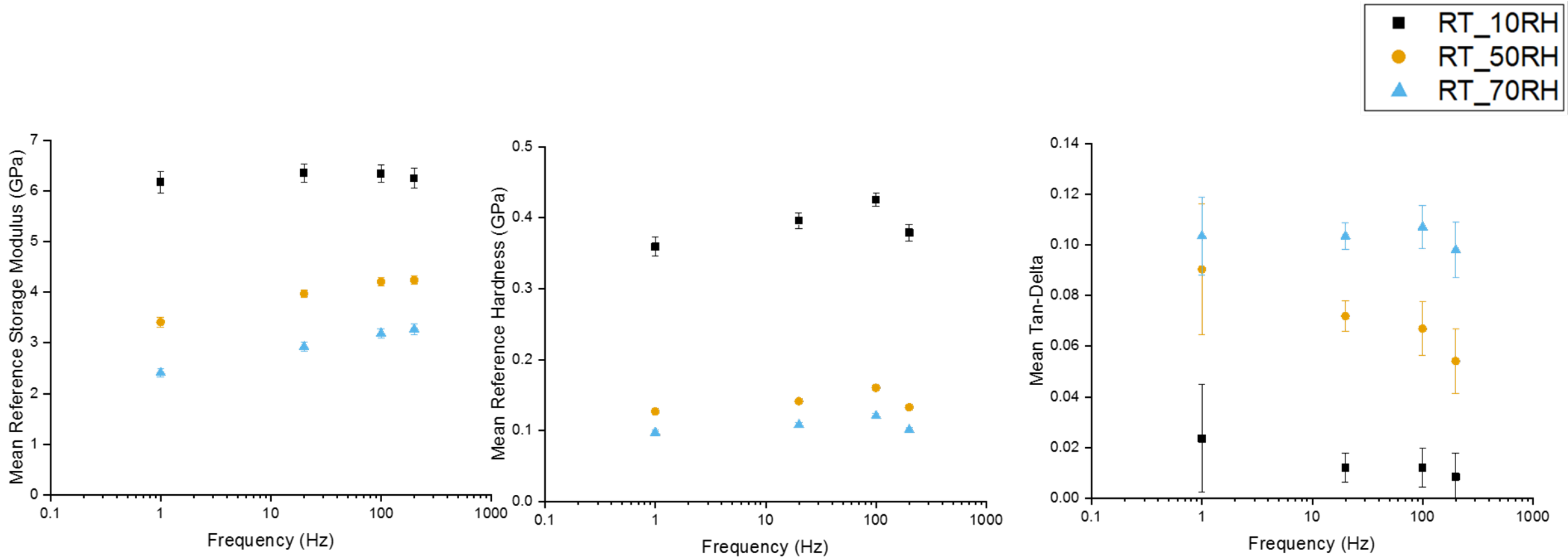
- 10% --> 50 % RH < 20 mins
- Measured humidity inside xSol
- Frequency = 20 Hz
- Room temperature

Humidity Testing of Glass Filled Nylon 66



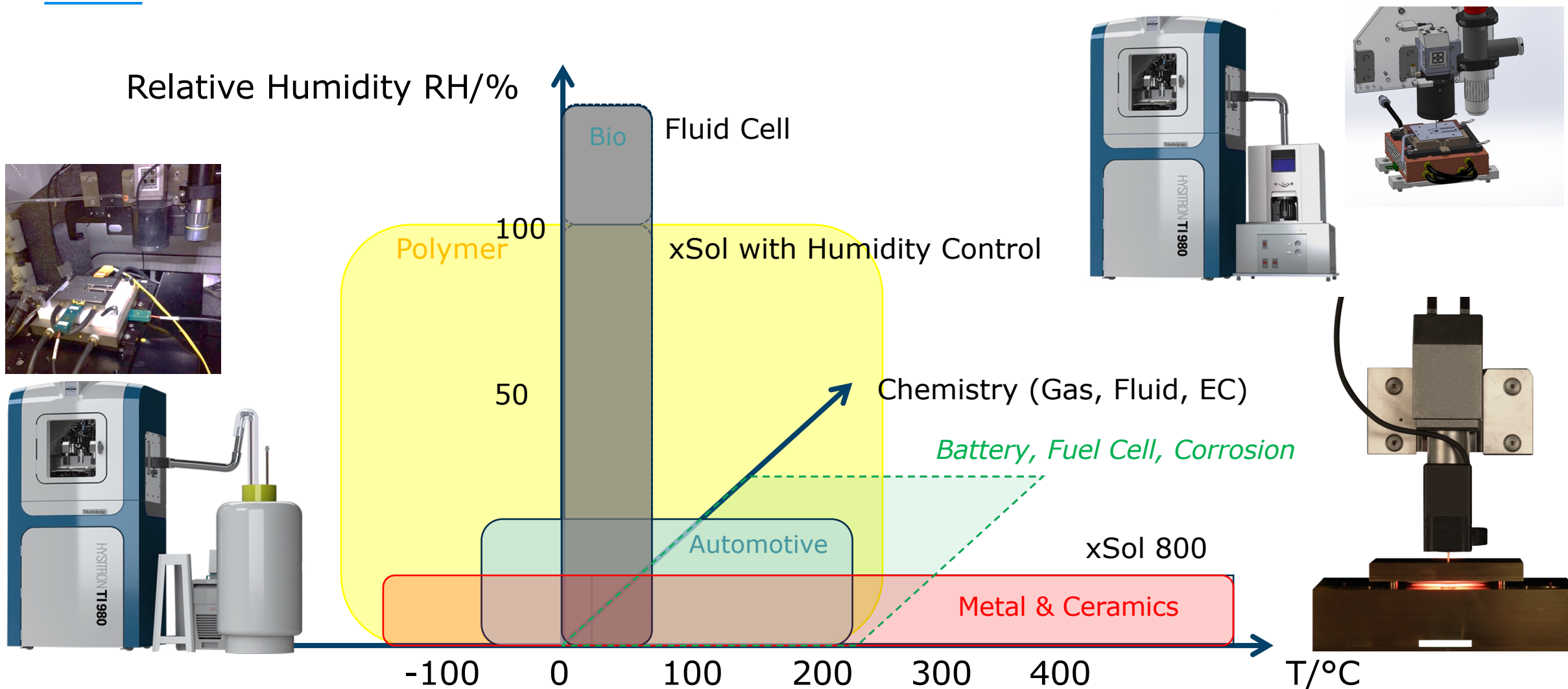
- 50 % --> 70% RH < 20 mins
- Measured humidity inside xSol
- Frequency = 20 Hz
- Room temperature

Humidity Testing of Glass Filled Nylon 66



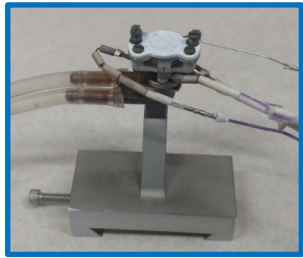
Take-Away

Expanding & Exploring a Larger Parameter Space

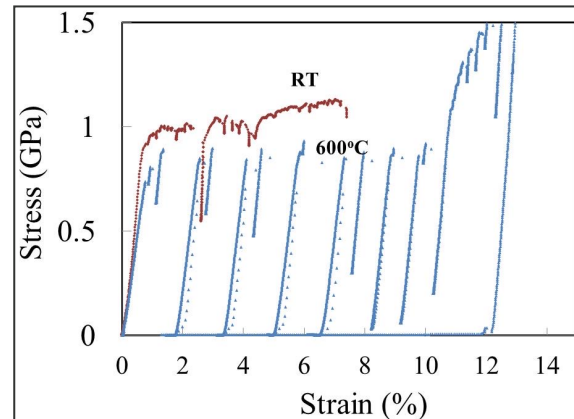
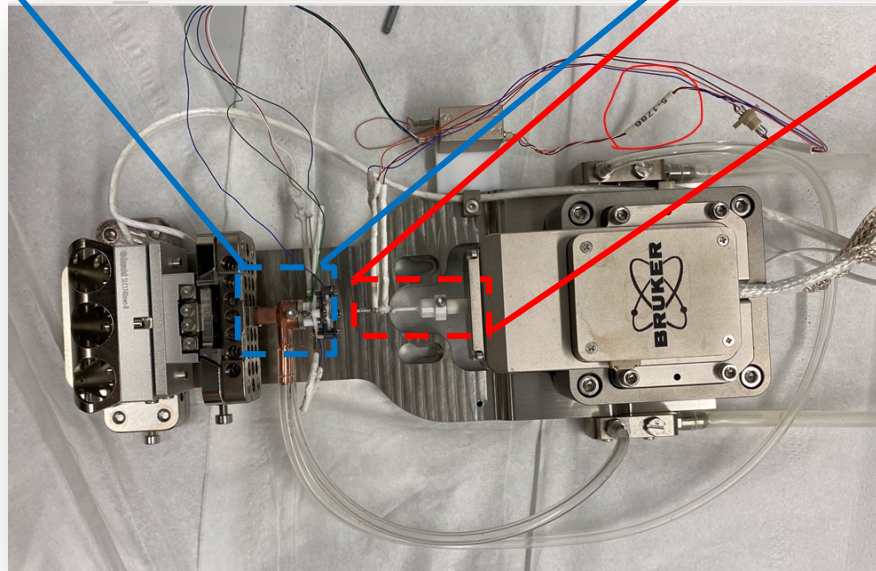
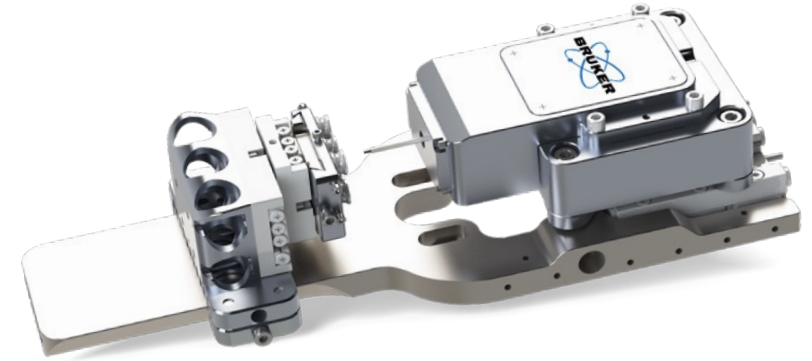
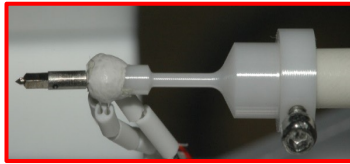


800°C Heating Option for *in-situ* SEM Tool of PI-89

Sample Heater

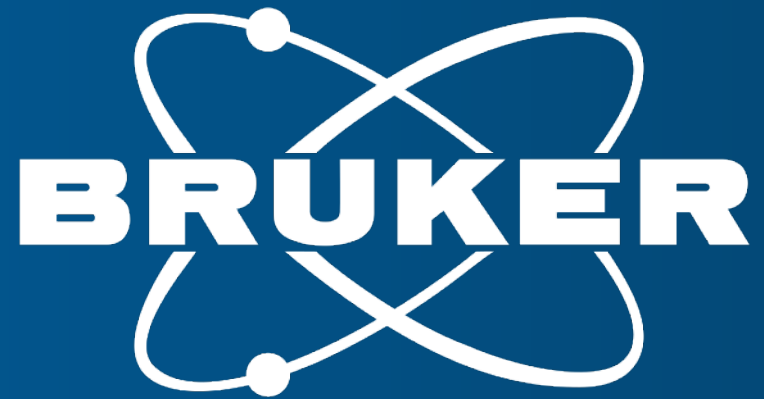


Probe Heater



- Independent tip and sample heaters, with separate feedback control
- Water cooling and thermal breaks to reduce heat flow into the system
- 800°C maximum temperature
- Up to 30°C/min ramp rates

www.bruker.com/Nanomechanical-testing



Innovation with Integrity